

# Capability of the 110 GHz Installation on the DIII-D Tokamak

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General Atomics

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2002 Meeting of the American Physical Society  
Division of Plasma Physics  
Orlando Florida



# Outline

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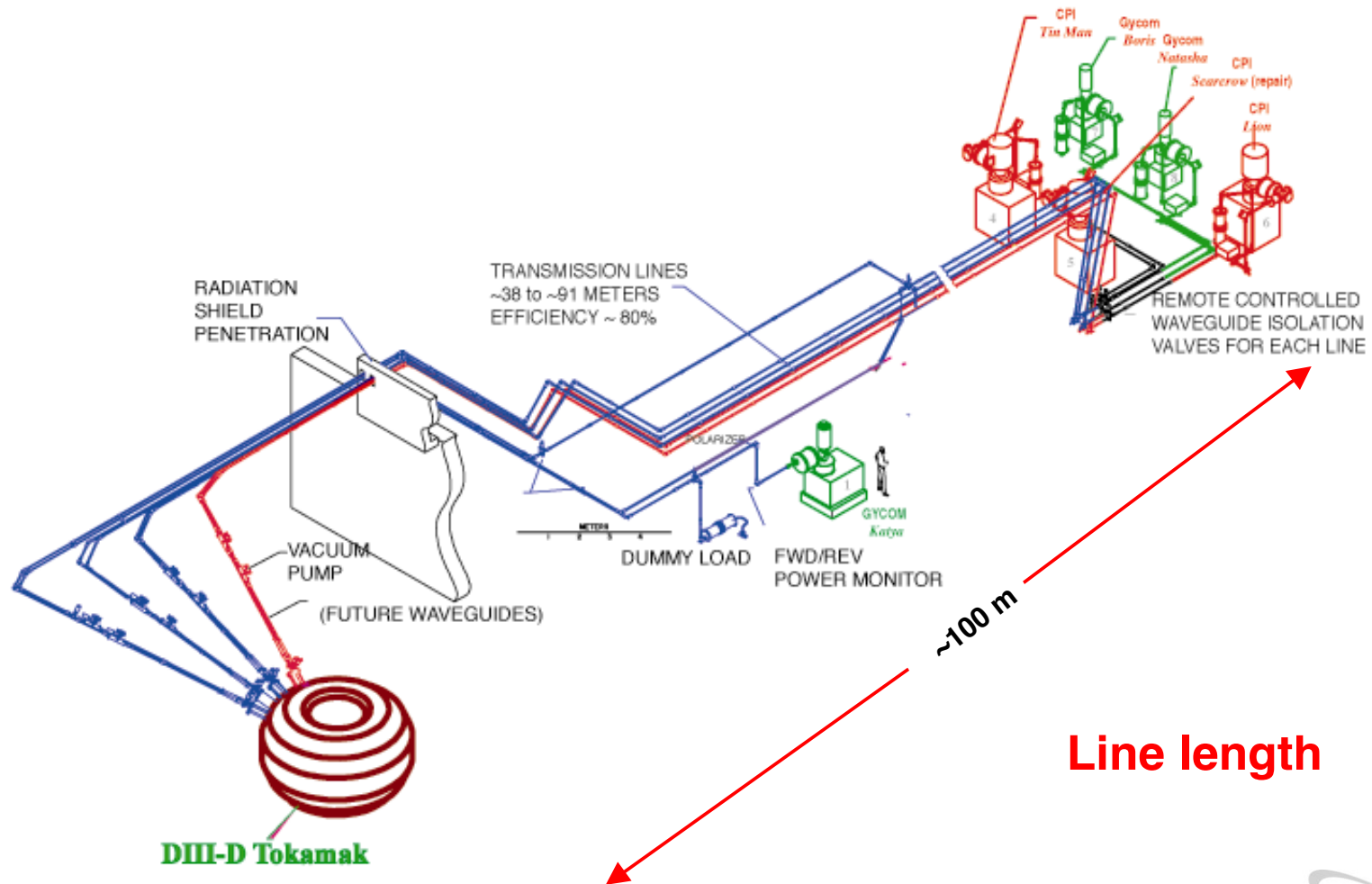
- **The 110 GHz ECH system**
  - Installation
  - Components
  - Capabilities and performance
  - CVD Diamond windows
- **Experiments**
  - Transport and power deposition (Casper LO1.003)
  - ECH/ECCD efficiency (DeGrassie LO1.011)
  - NTM suppression (Petty LO1.007, Prater QP1.075)
  - Feedback control of injected rf power (Wade LO1.008)
  - Advanced tokamak operation (Murakami FI1.002, Greenfield LO1.002, St. John RP1.032)
- **Summary and future plans**



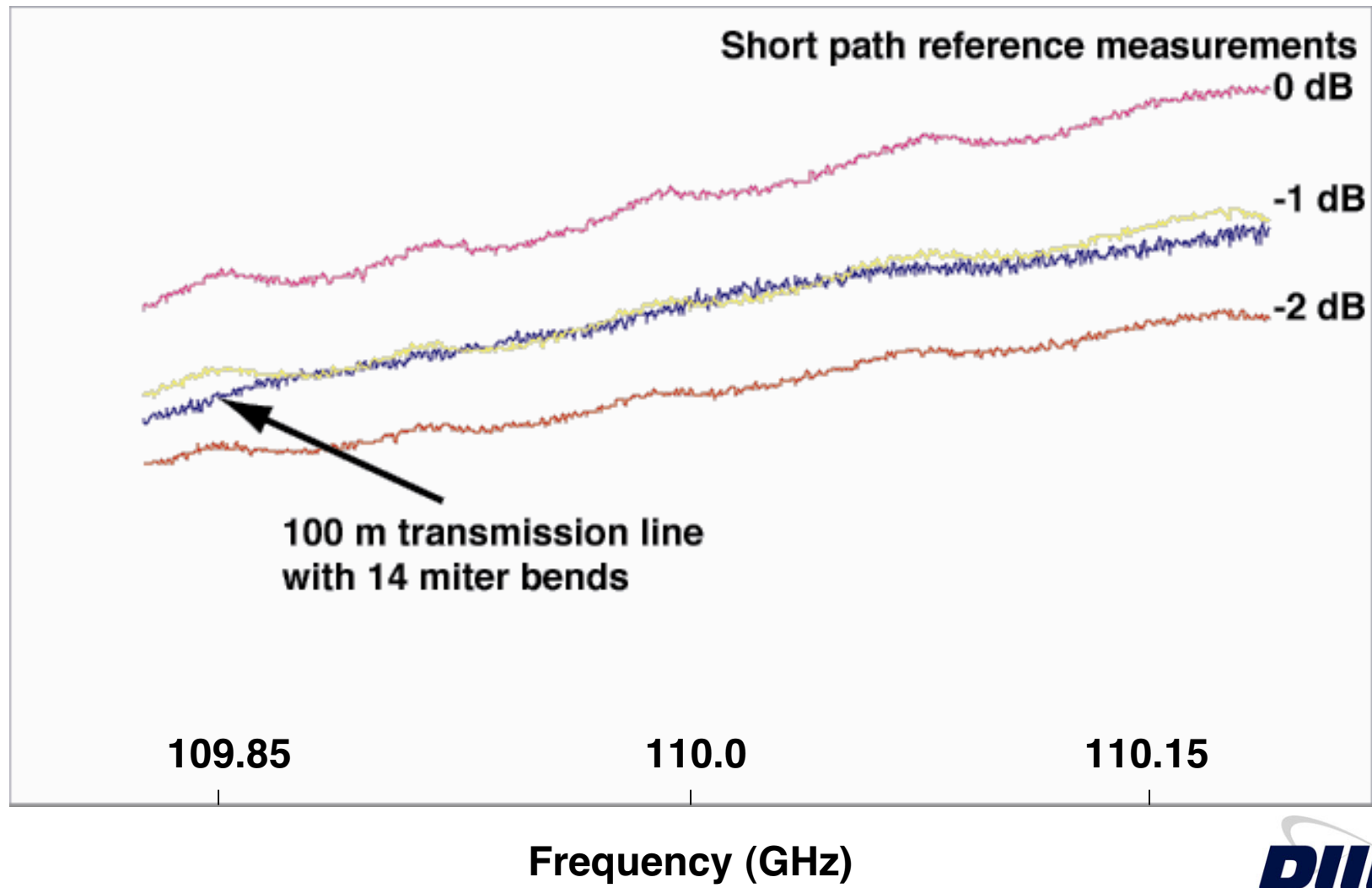
# The DIII-D ECH Installation



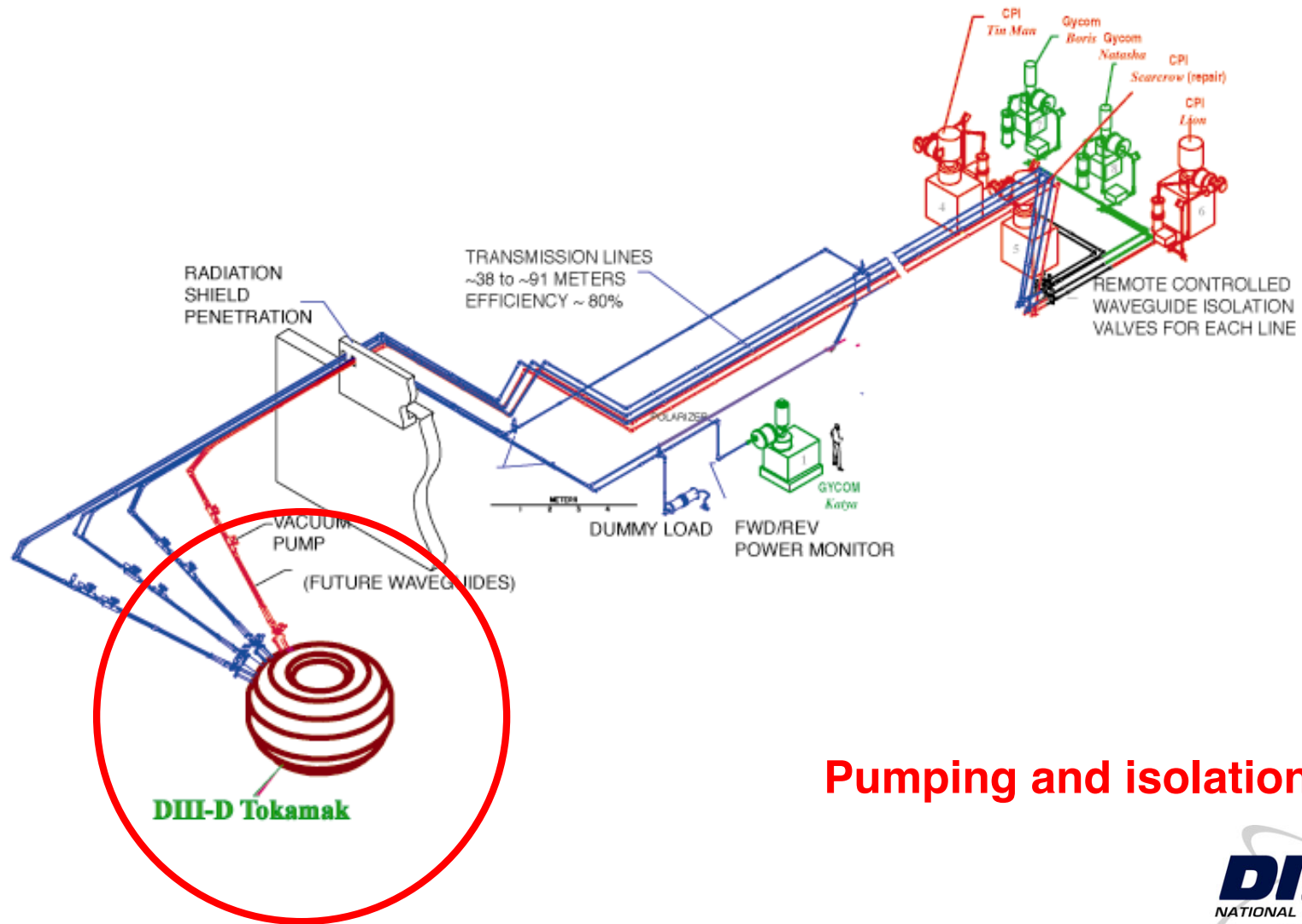
# The DIII-D ECH System



# Transmission Line Efficiency >80% for 100m Length



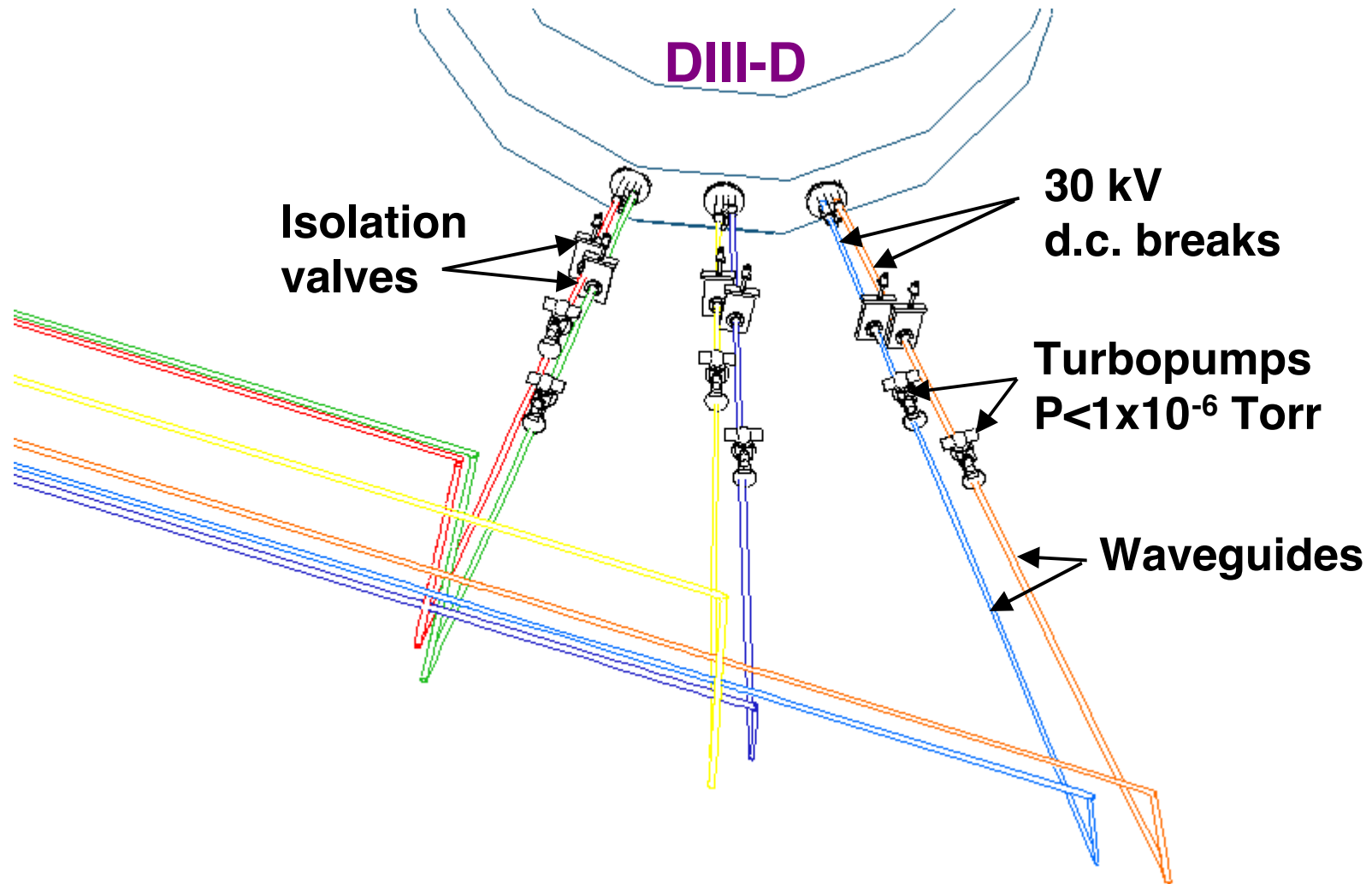
# The DIII-D ECH System



**Pumping and isolation**

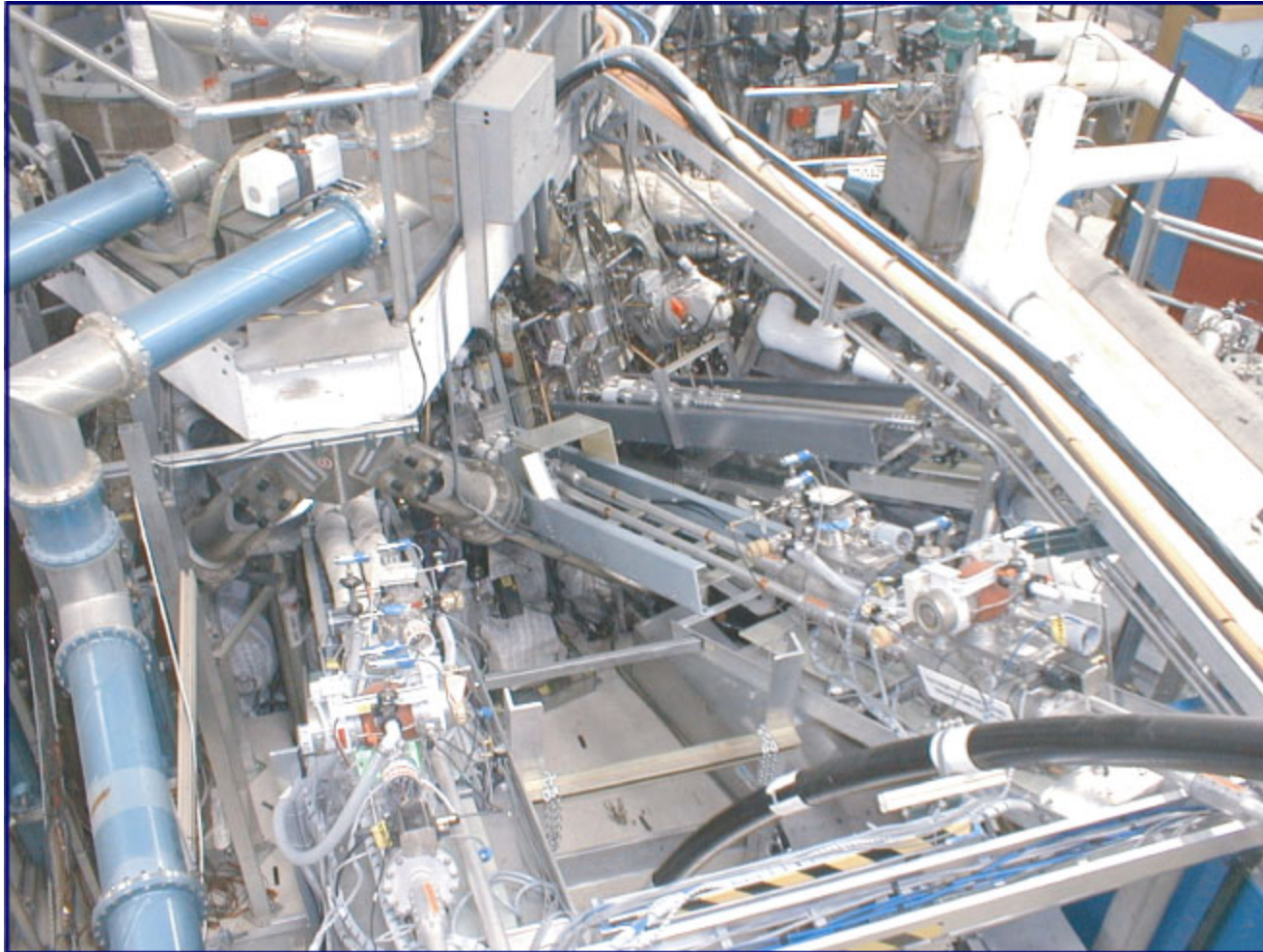


# Waveguide Lines at DIII-D



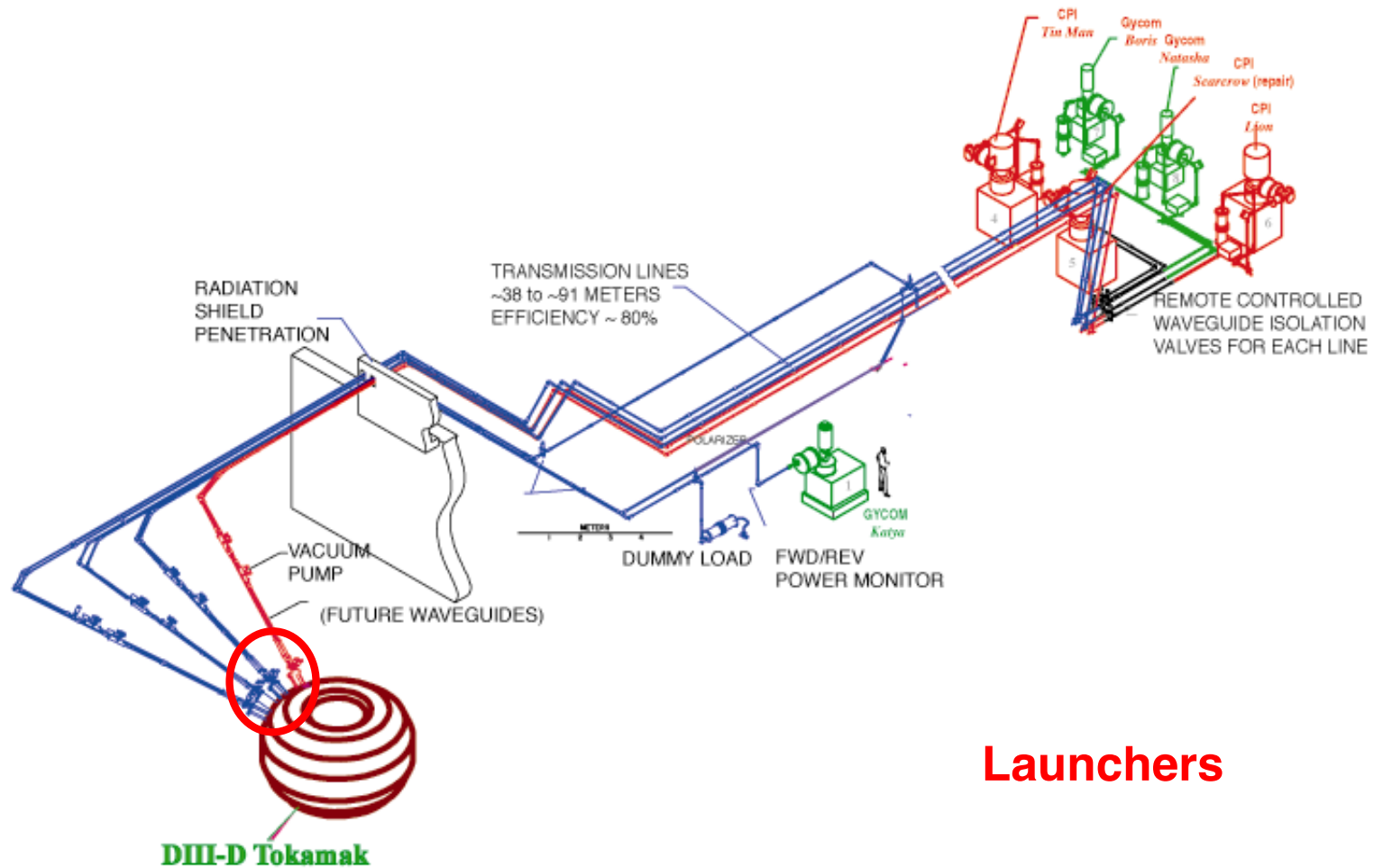
# ECH Waveguides at DIII-D

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# The DIII-D ECH System

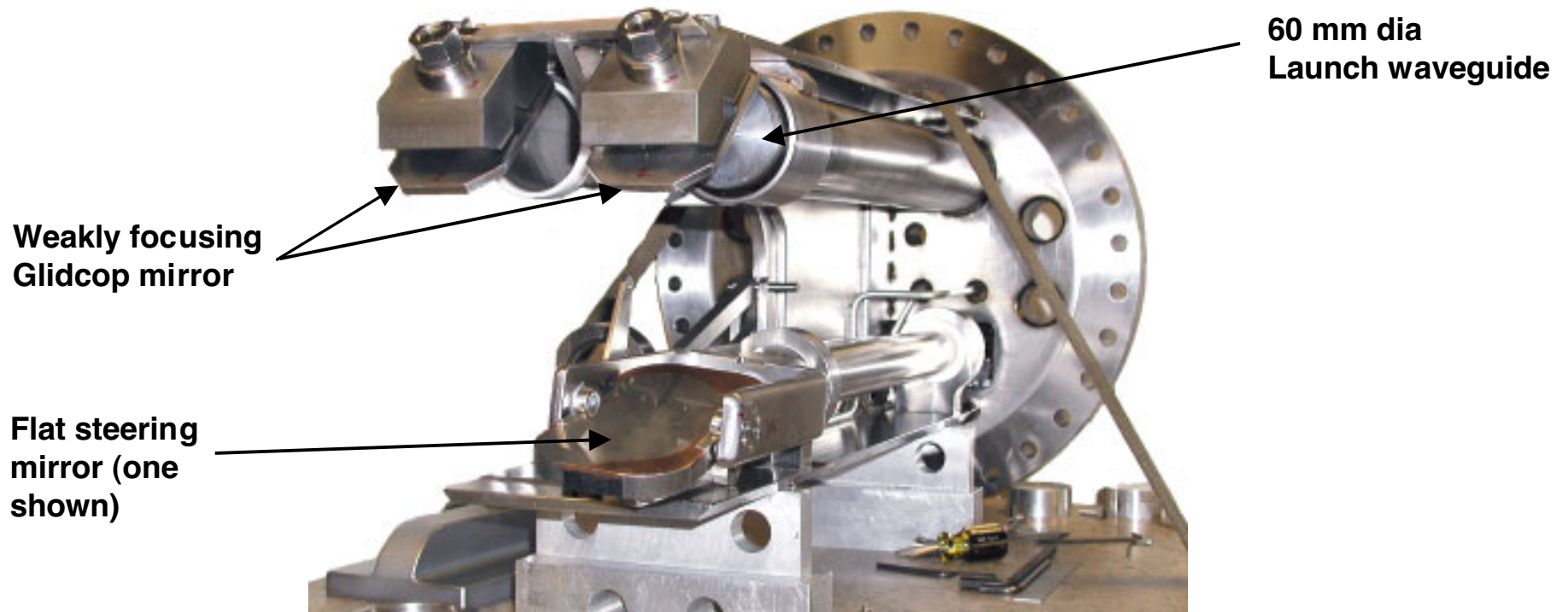


**Launchers**



# Articulating Launchers

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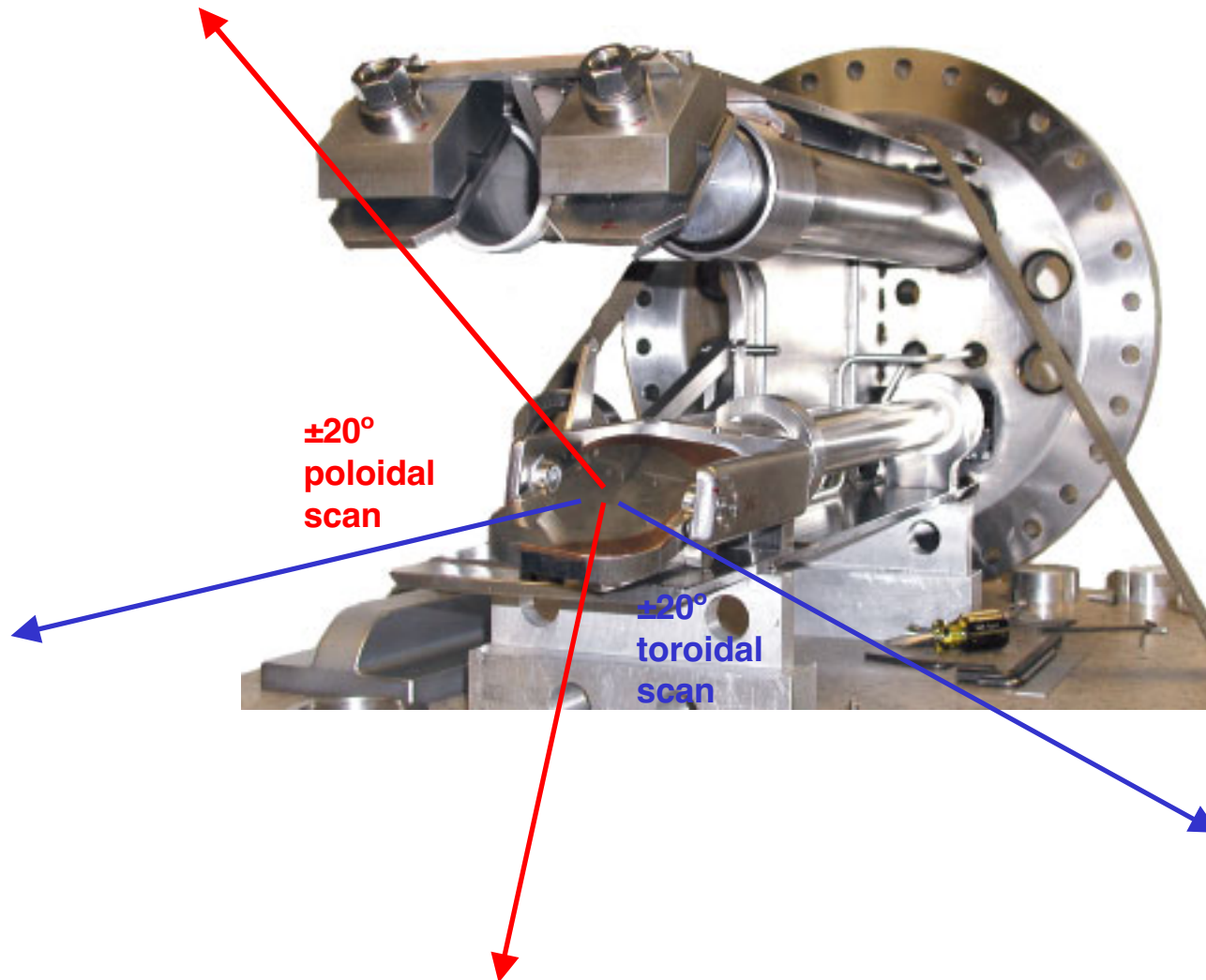


- Three fully articulating dual launchers are now installed on DIII-D
- Two launchers have fast mirror scan capability

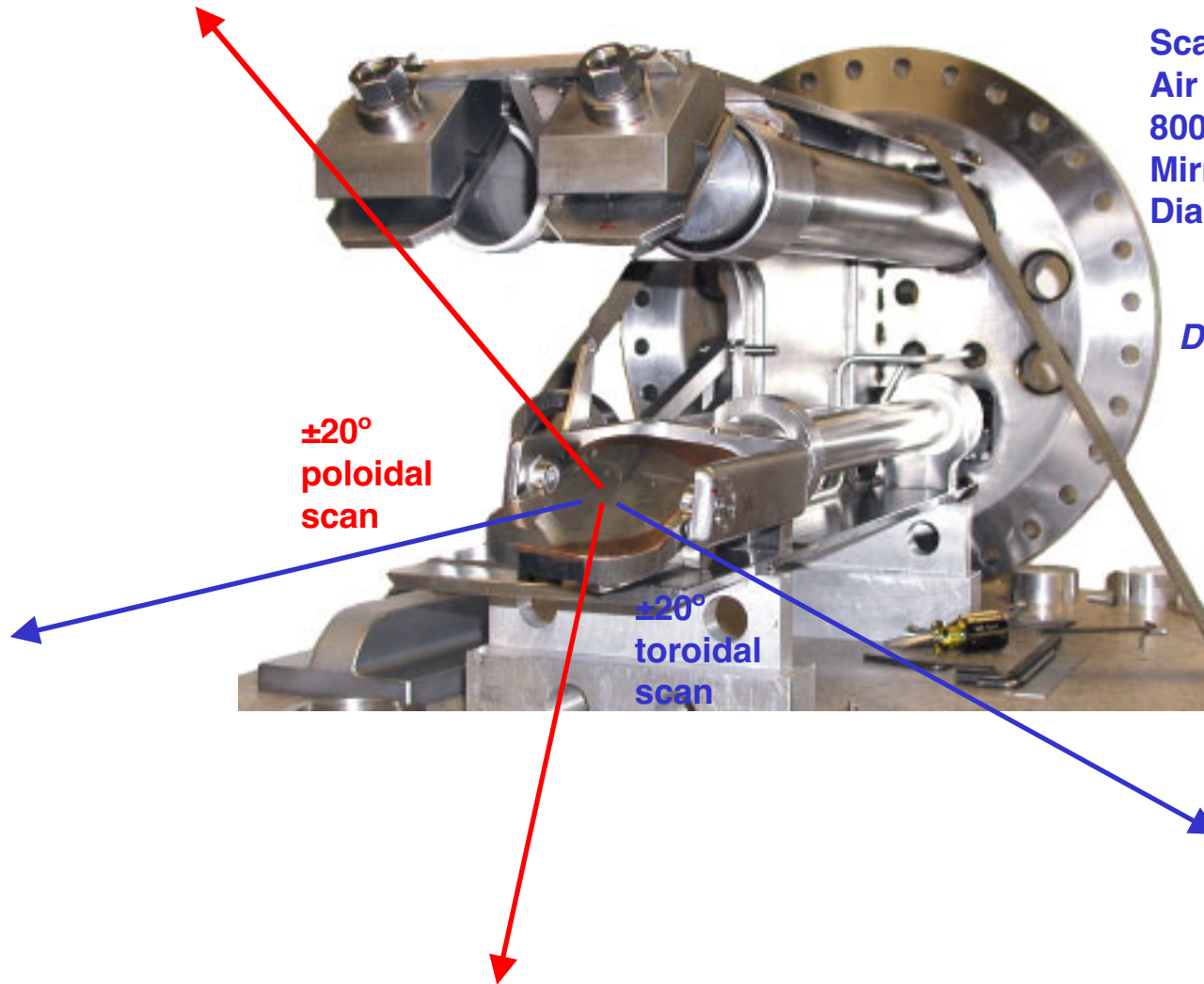


# Articulating Launcher Scan

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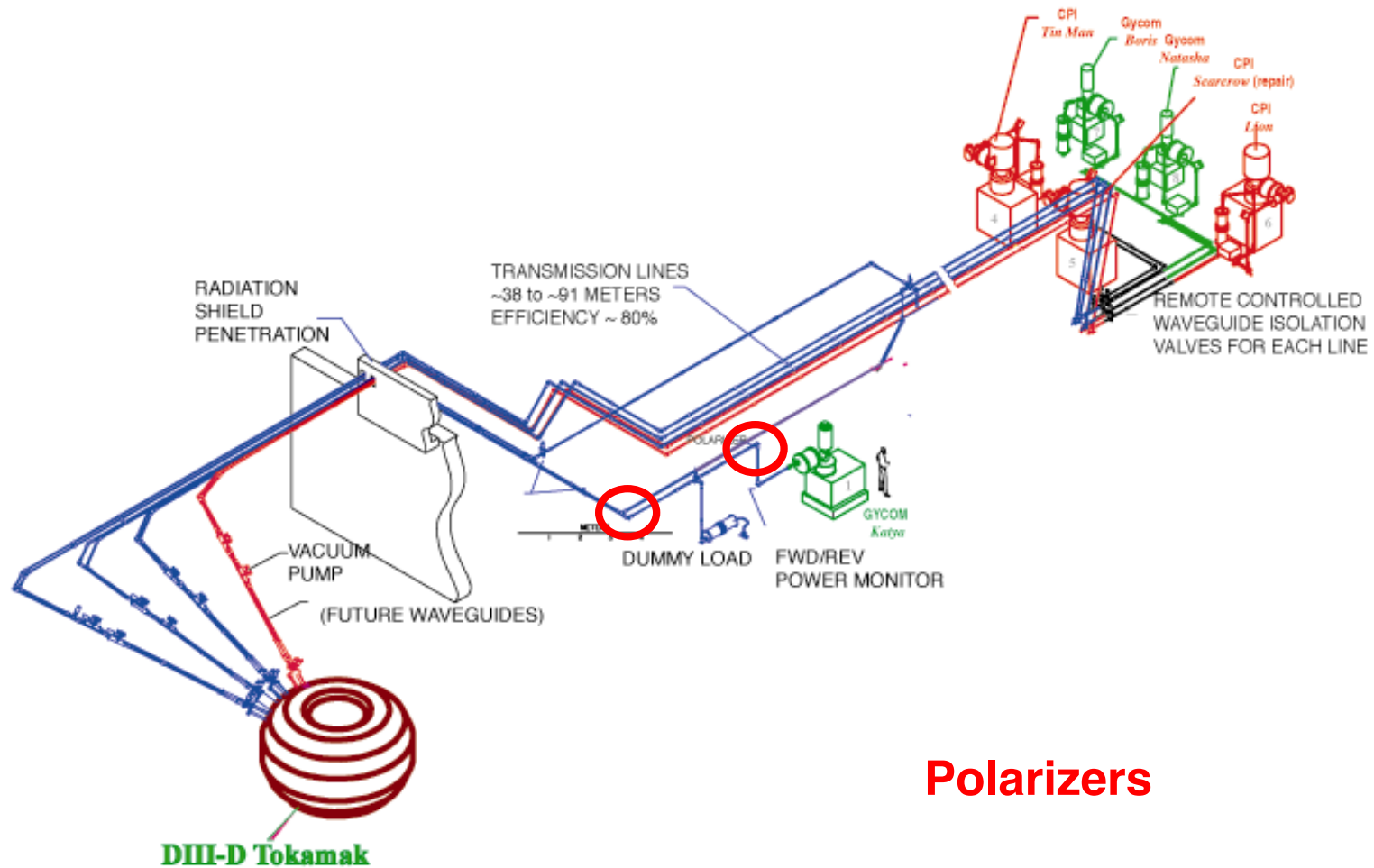


# Articulating Launcher Scan



Scan rates  $\sim 10^\circ/\text{sec}$   
Air turbine drive motors  
800 kW, 10 sec pulse every 10 min  
Mirrors cooled by radiation  
Diagnostics: Langmuir probes  
TV cameras  
RTD thermal monitors  
*Designed and built by PPPL*

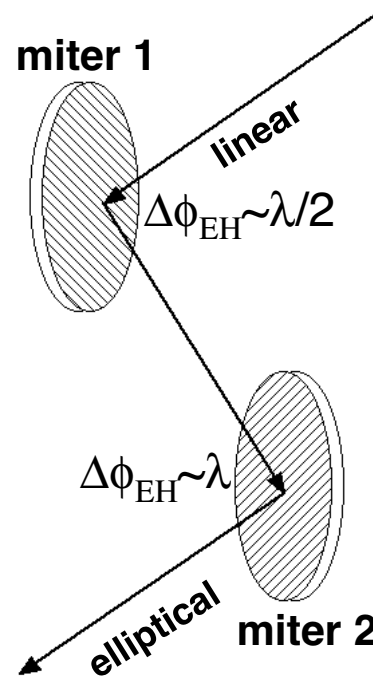
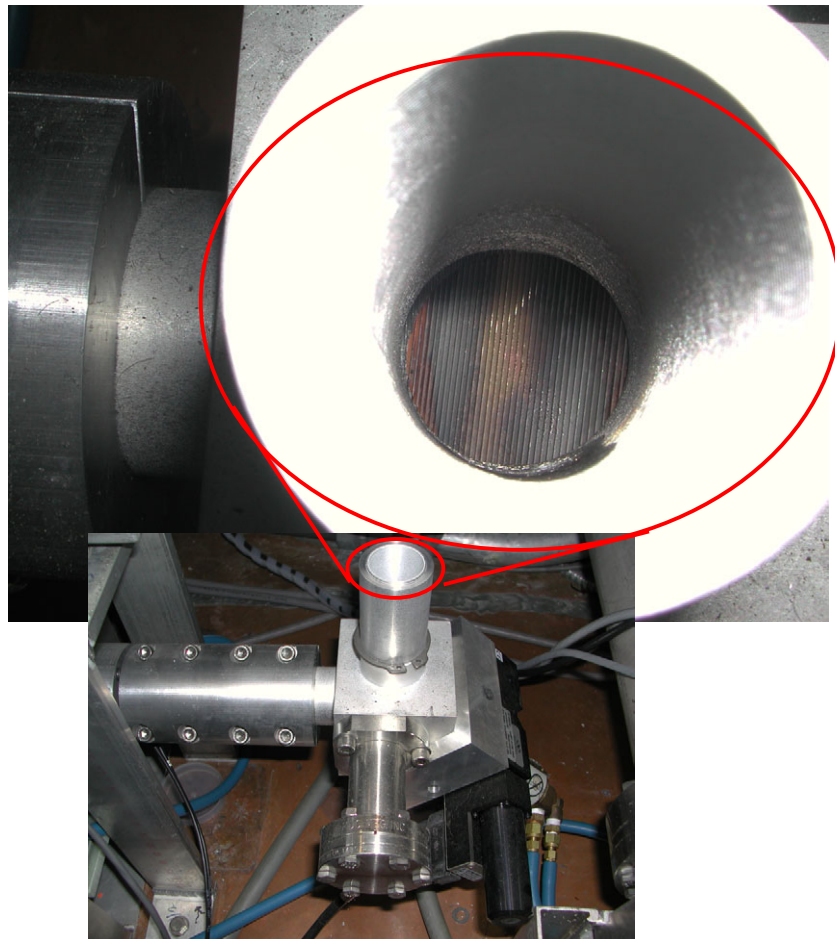
# The DIII-D ECH System



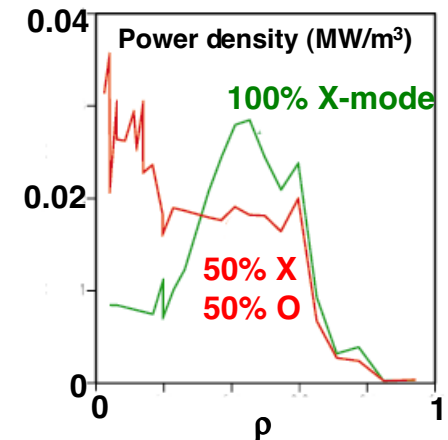
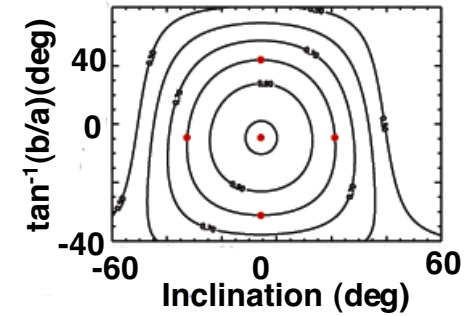
**Polarizers**



# Polarizer Pairs Give Arbitrary Elliptical Polarization in Vacuum Under Remote Control



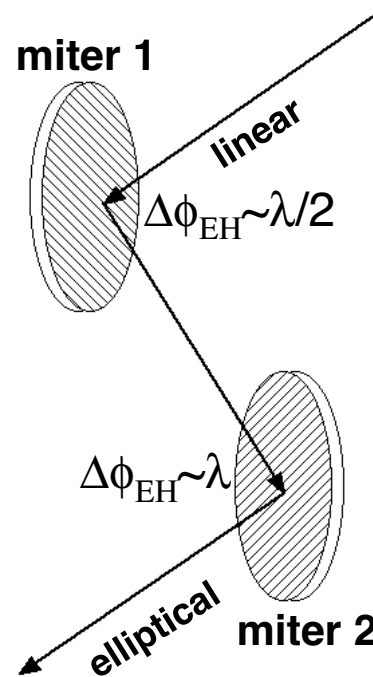
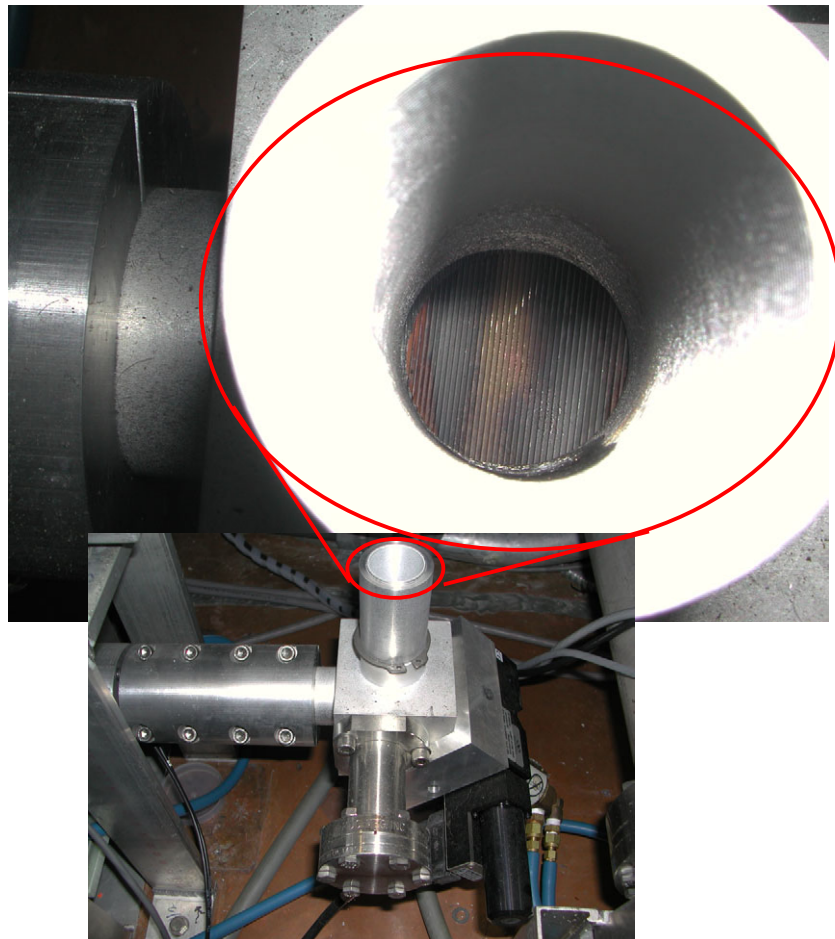
Polarizers are two grooved miter mirrors and produce arbitrary elliptical polarization.



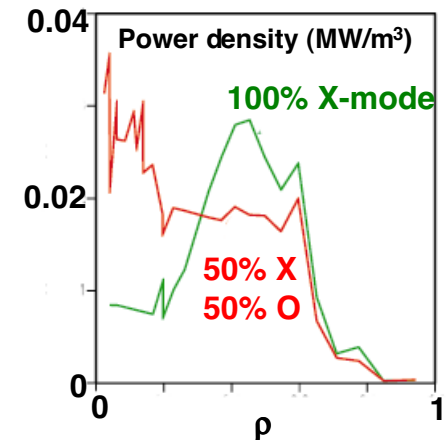
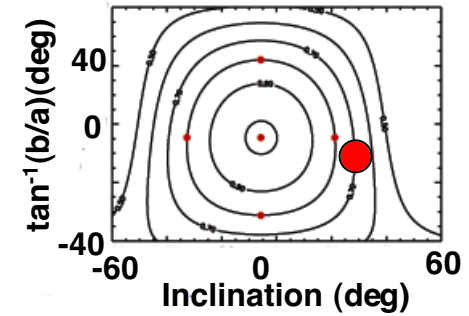
The measured power deposition profile becomes a polarization diagnostic.



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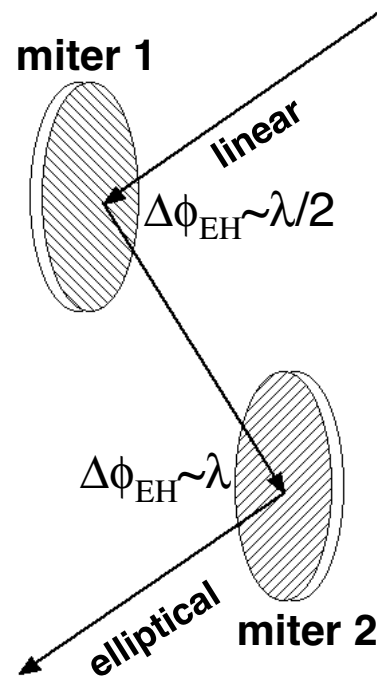
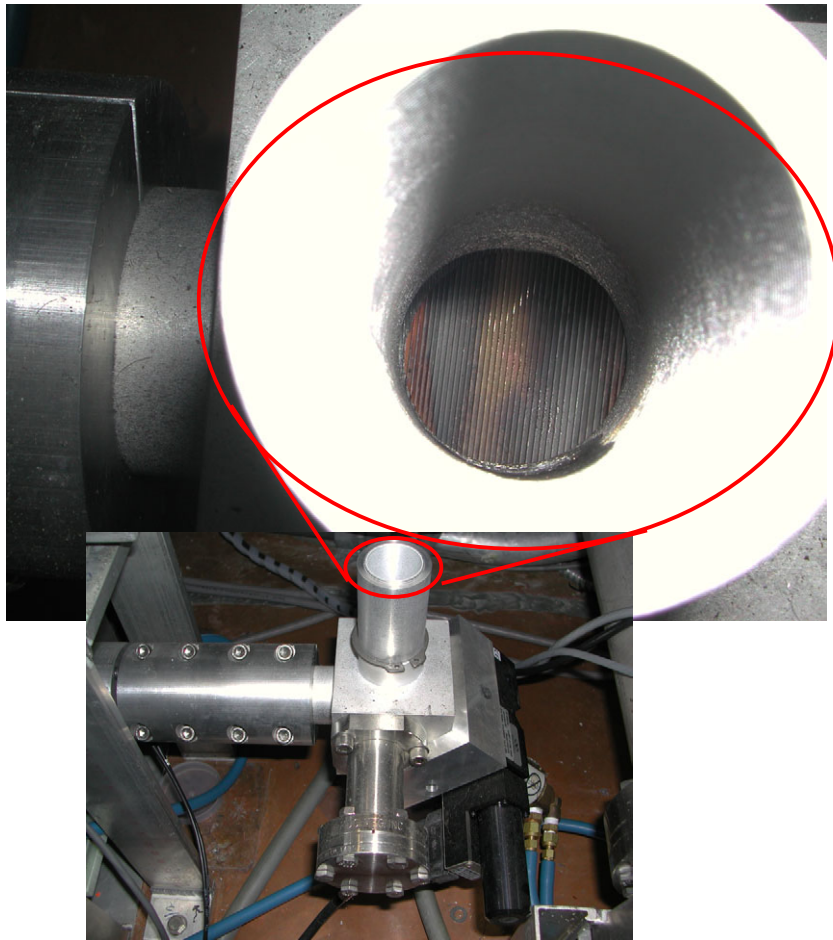
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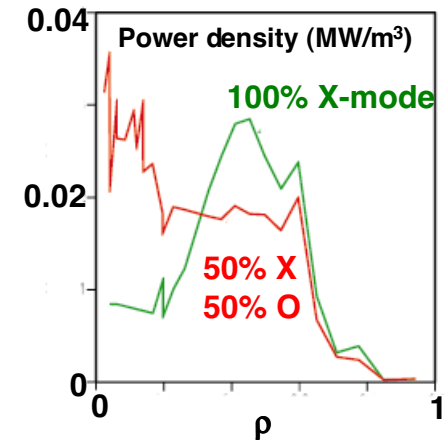
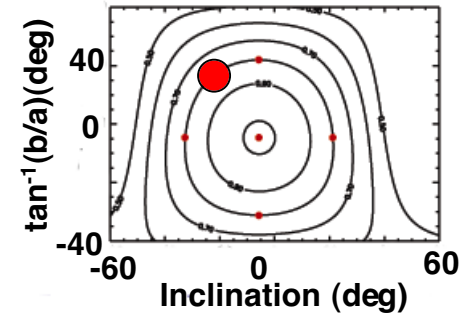
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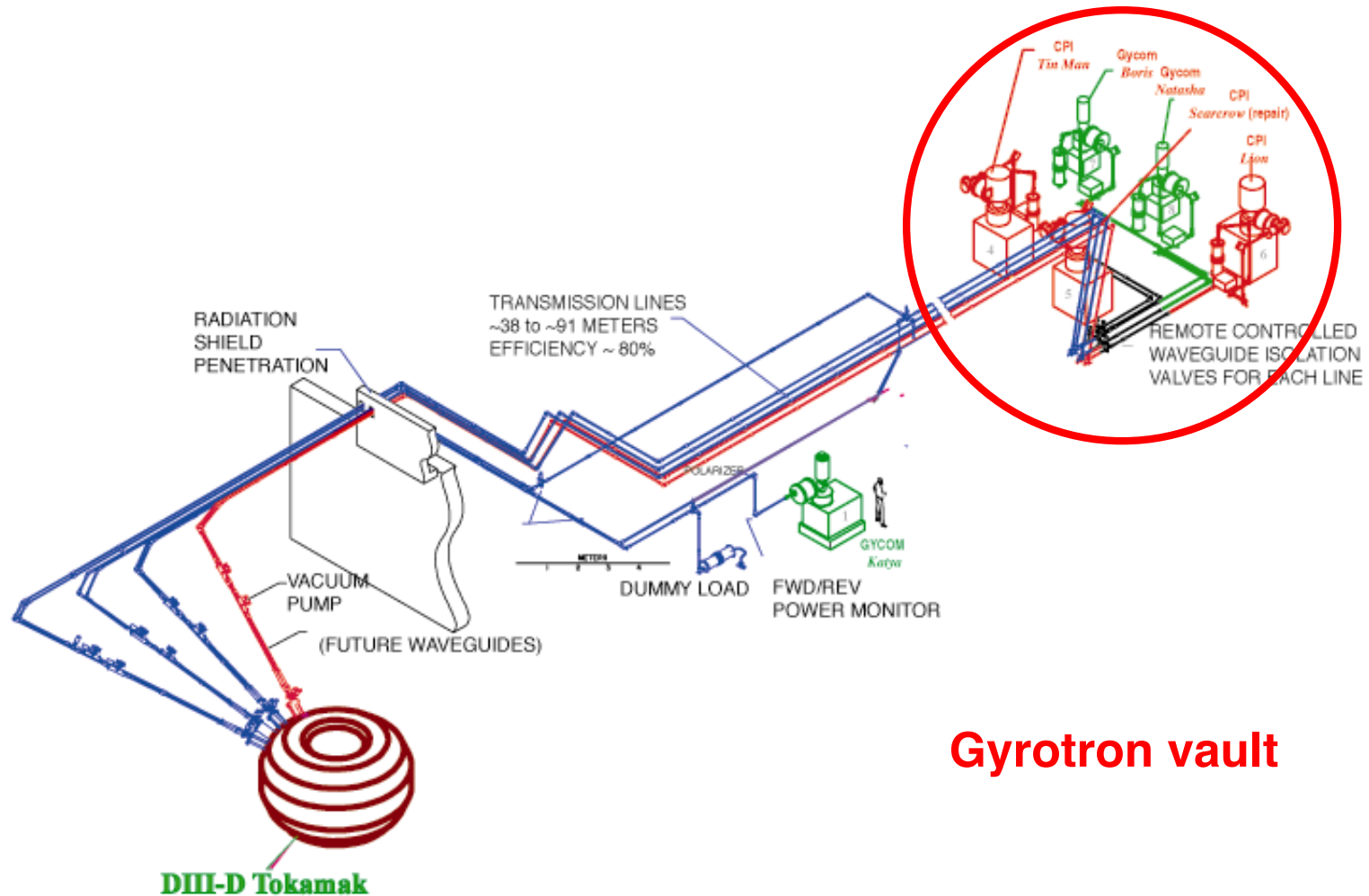


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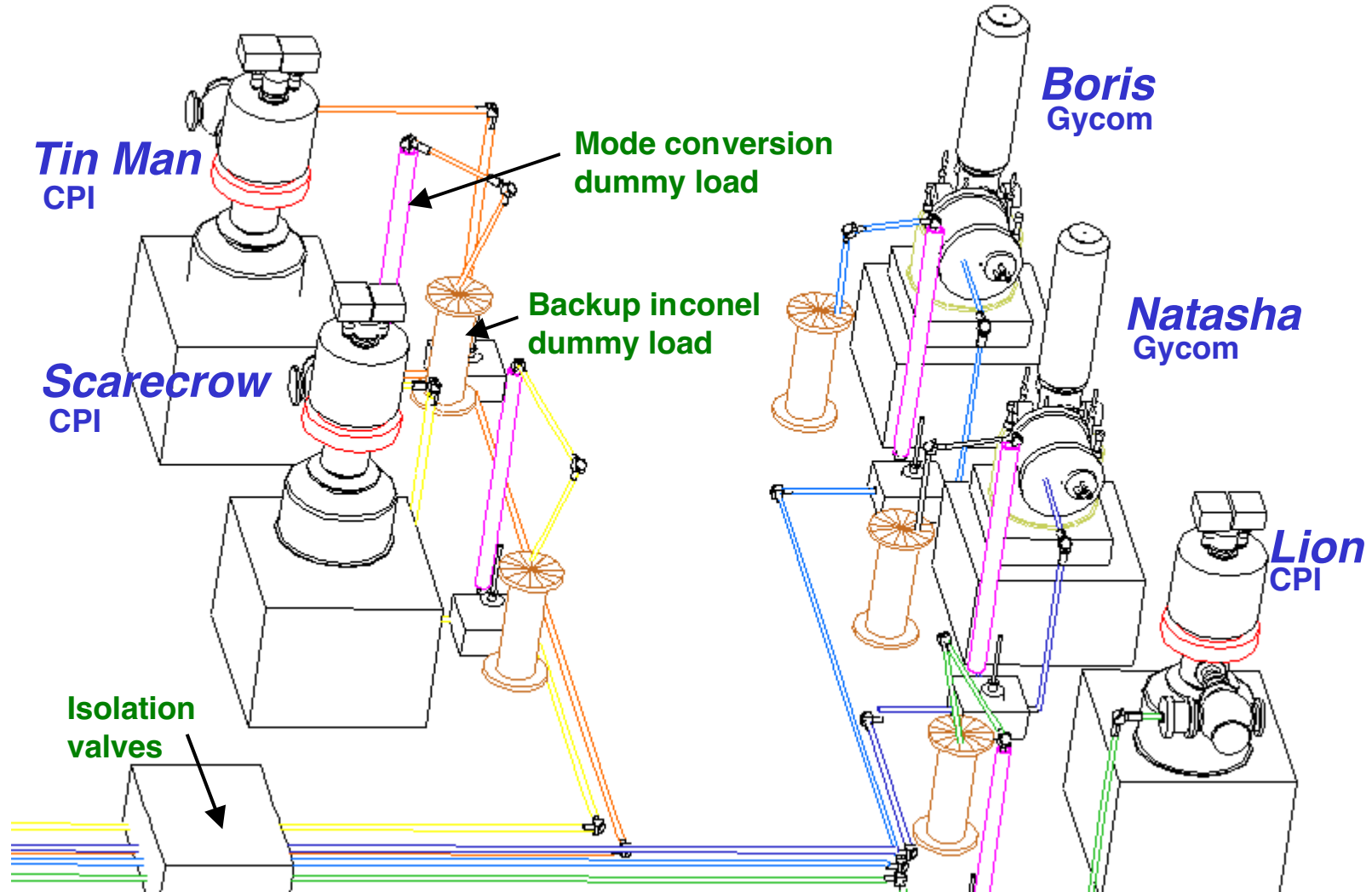


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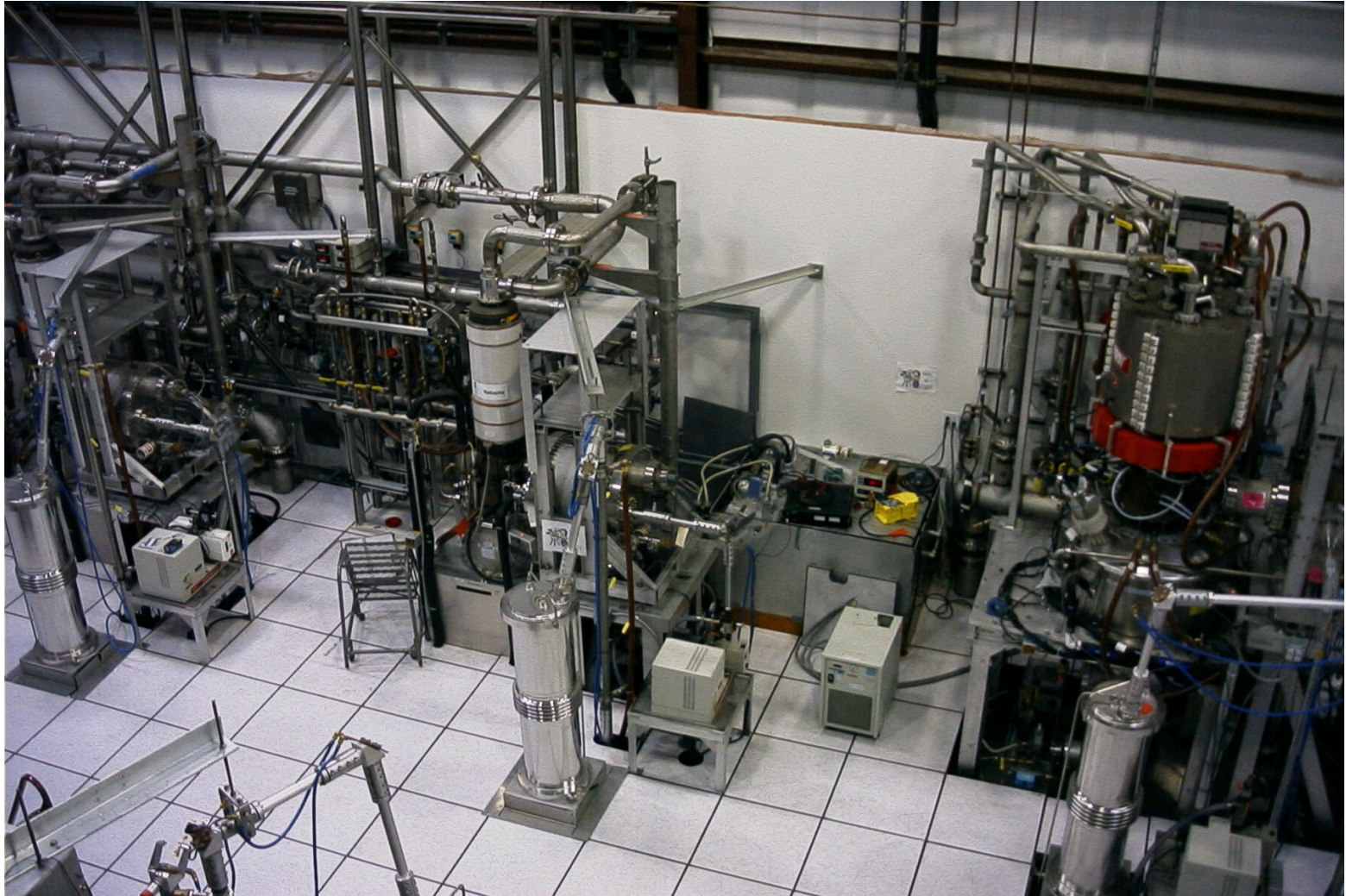


**Gyrotron vault**

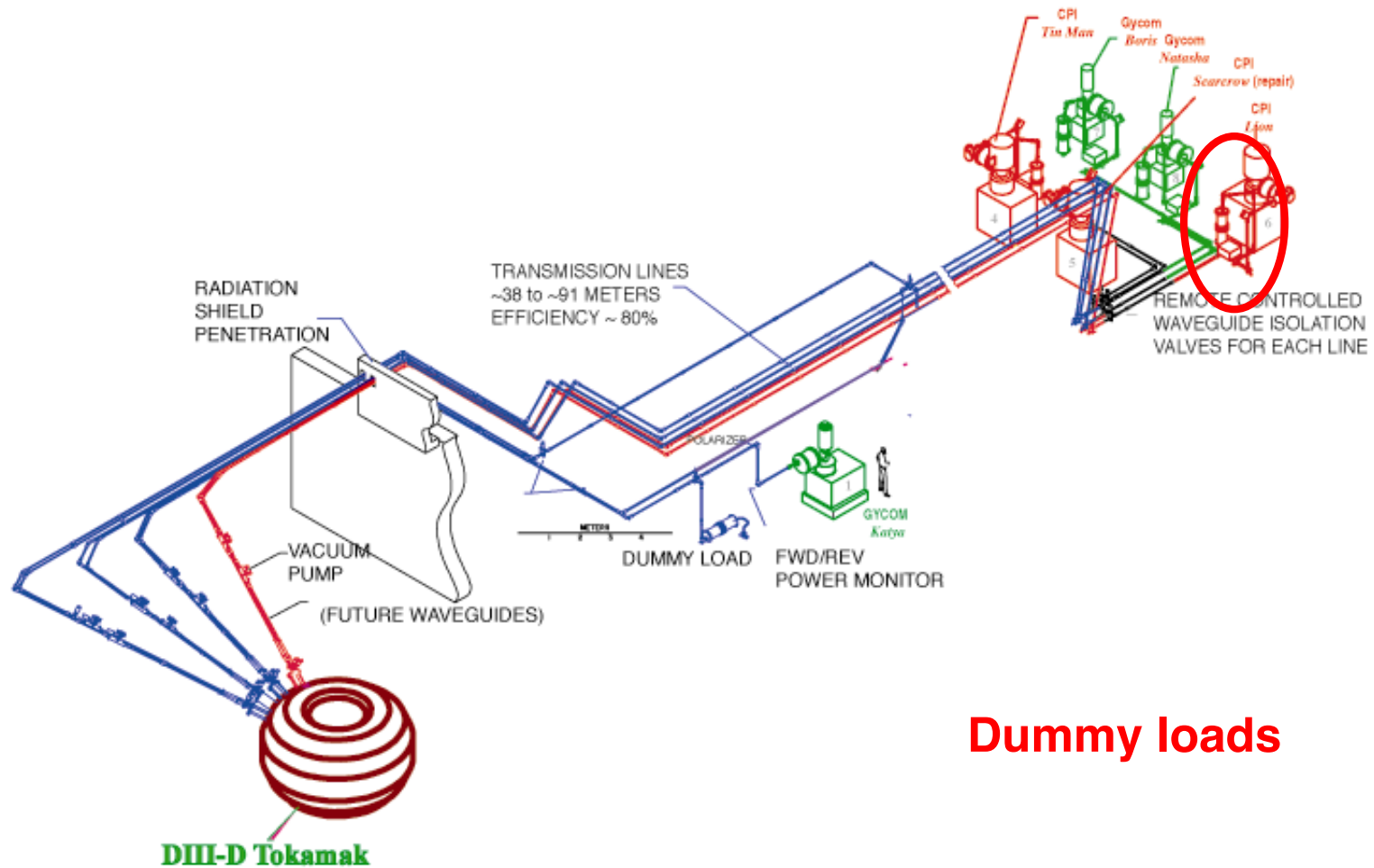
# ECH Gyrotron Vault



# □ECH Gyrotron Vault



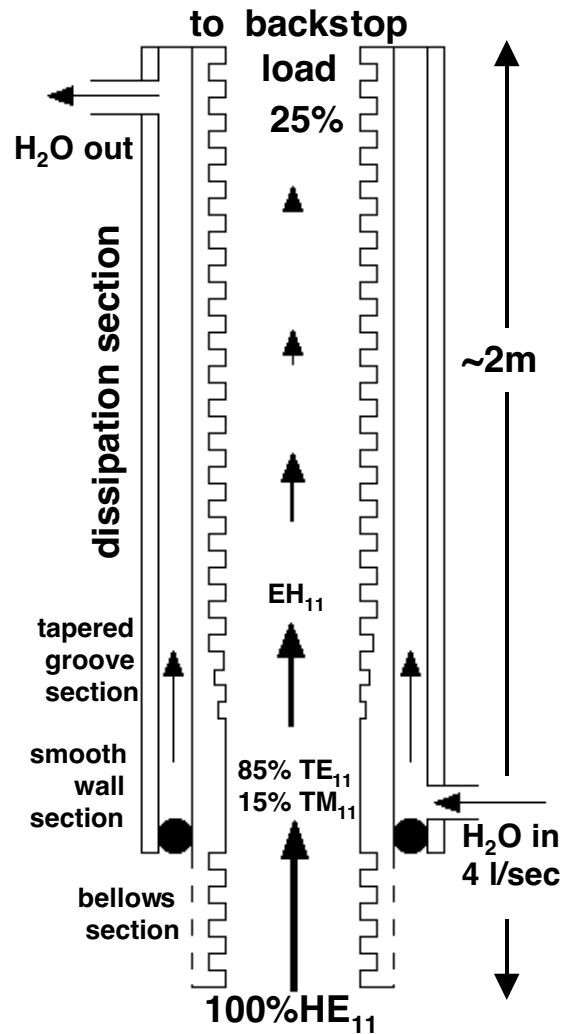
# The DIII-D ECH System



**Dummy loads**

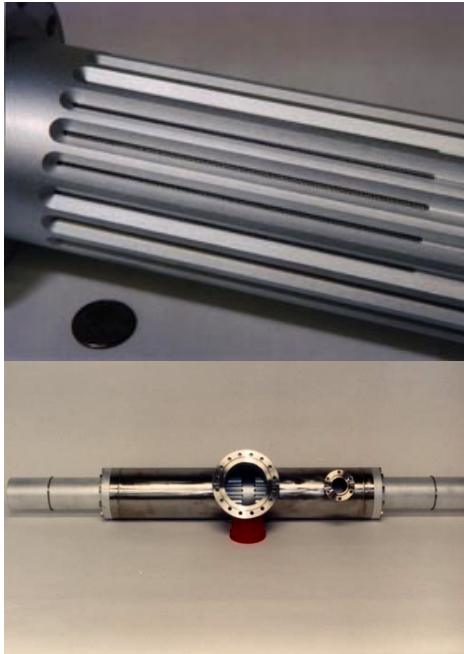


# Dummy Loads for 1 MW cw (they're not just pieces of pipe)



# Unique Components

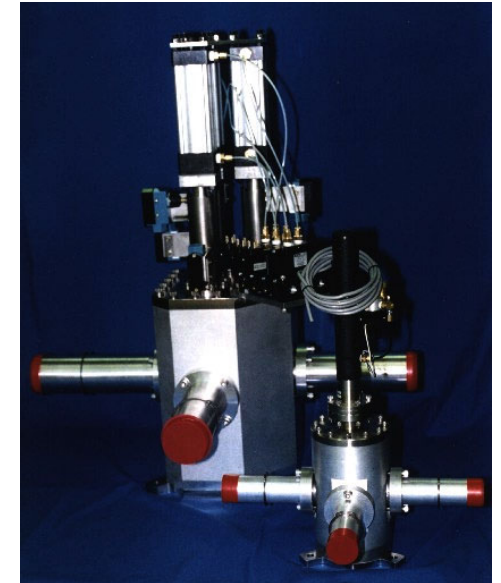
Vacuum pumpouts



Bellows and other specialized components



Waveguide switches



Miter bends and polarizing miter bends

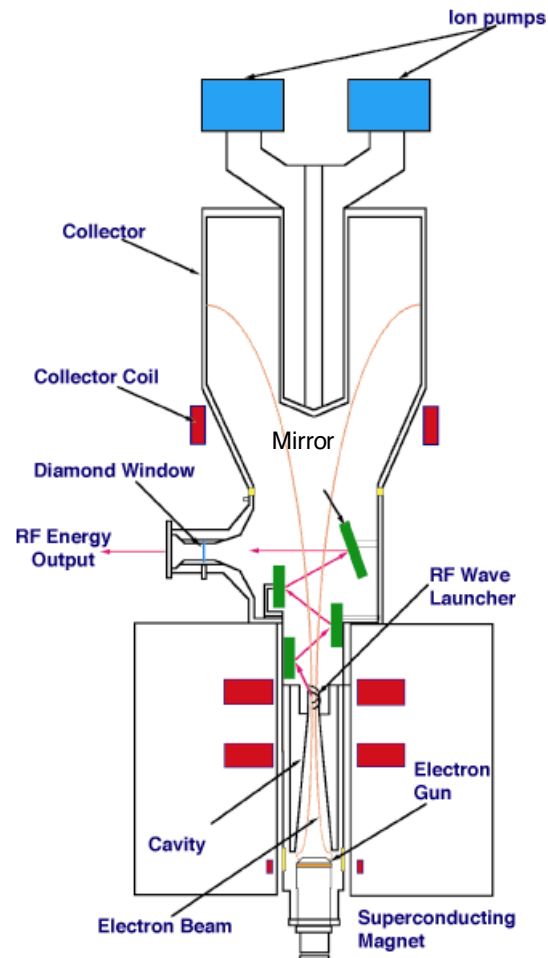
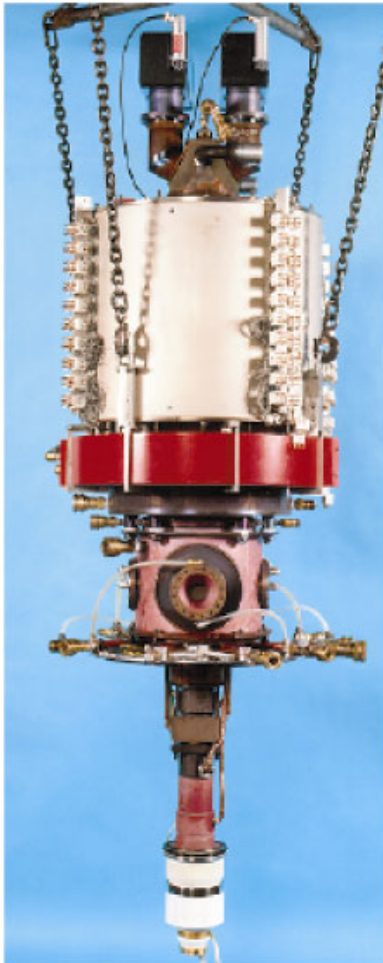


Power monitor miter bends



Corrugated vacuum waveguides

# Modern 1 MW Class Gyrotrons at 75-170 GHz



- Production, R&D
  - CPI (US)
  - Gycom (Russia)
  - Thales (France)
  - Toshiba (Japan)
- R&D
  - MIT, CCR, UMd, UW (US)
  - IAP, StPSTU (Russia)
  - FzK, CRPP, U. Stuttgart (EU)
  - JAERI, Fukui Univ. (Japan)
  - U. Helsinki (Finland)
  - deBeers, Fraunhofer Inst (EU)



# DIII-D Gyrotron Parameters and Power Balance

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<b>GYROTRON NAME (mfg)</b>	<b>PULSE LENGTH (SEC)</b>	<b>V<sub>beam</sub> (kV)</b>	<b>I<sub>beam</sub> (A)</b>	<b>EFF (%)</b>	<b>P<sub>win</sub> (kW) (%)</b>	<b>P<sub>mon</sub> (kW) (%)</b>	<b>P<sub>gen</sub> (kW)</b>
<b>Katya (G1) (Gycom)</b>	<b>2.1</b>	<b>72</b>	<b>31</b>	<b>31</b>	<b>33 3.7</b>	<b>173 25</b>	<b>699</b>
<b>Boris (G2) (Gycom)</b>	<b>2.1</b>	<b>69</b>	<b>30</b>	<b>37</b>	<b>30 3.9</b>	<b>136 18</b>	<b>775</b>
<b>Natasha (G3) (Gycom)</b>	<b>2.1</b>	<b>69</b>	<b>30</b>	<b>30</b>	<b>25 4.1</b>	<b>123 20</b>	<b>611</b>
<b>Tin Man (P2) (CPI)</b>	<b>5.0</b>	<b>80</b>	<b>40</b>	<b>30</b>	<b>2.1 0.22</b>	<b>69 7</b>	<b>955</b>
<b>Lion (P3) (CPI)</b>	<b>5.0</b>	<b>78</b>	<b>41</b>	<b>31</b>	<b>2.8 0.28</b>	<b>42 4</b>	<b>983</b>
<b>Scarecrow (P1) (CPI)</b>	<b>10.0</b>	<b>82</b>	<b>26</b>	<b>25</b>	<b>1.6 0.3</b>	<b>N/A</b>	<b>531</b>

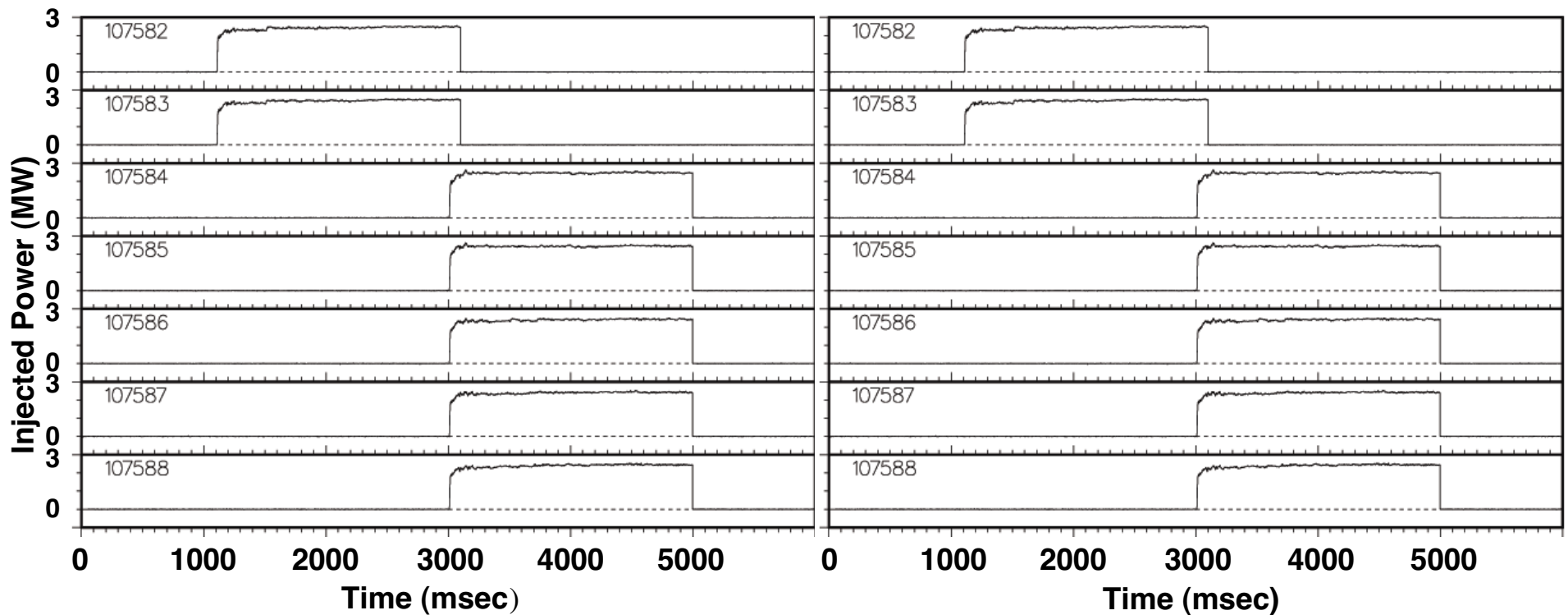
**P<sub>Σ</sub>=4.554 MW**





# ECH Reliability is Comparable to NBI

## 14 Consecutive shots with 4 gyrotrons

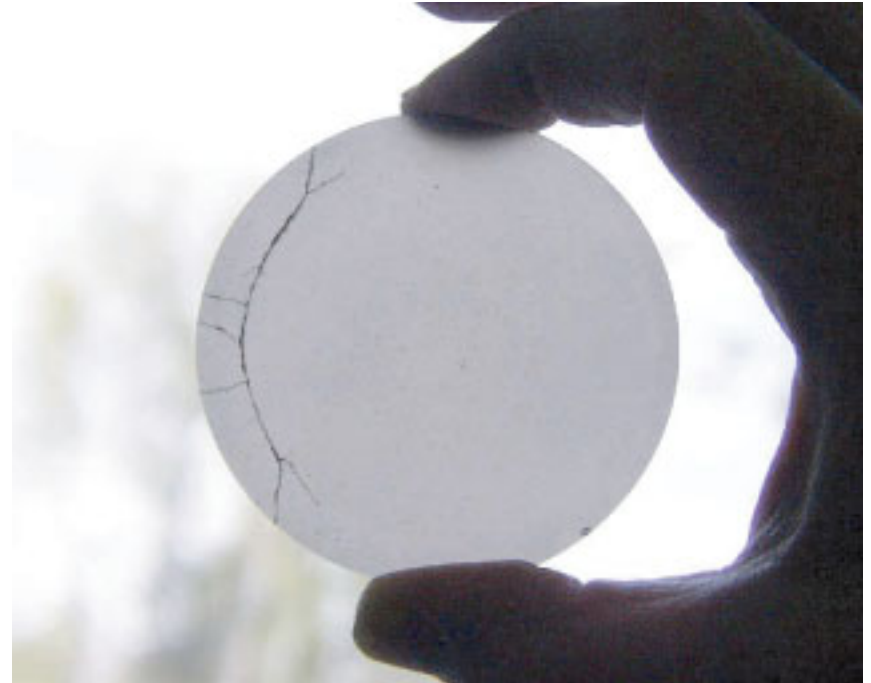


# CVD Diamond Windows for Gyrotrons

# Diamond is the Answer, but with a Learning Curve



Chemical Vapor Deposition  
diamond disks for high power  
gyrotron output windows



*Scarecrow* window found broken  
under the aluminum braze when  
the leaking flange was removed



# Early difficulties with CVD diamond windows...

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- Corrosion of aluminum based flange brazes
- Stresses arising during the braze process
- Surface contamination arising during brazing
- Surface contamination arising during bakeout
- Surface contamination arising during cleaning(!)
- Hydrogen “end bonding” increasing losses
- Failure due to arc initiated in dummy load

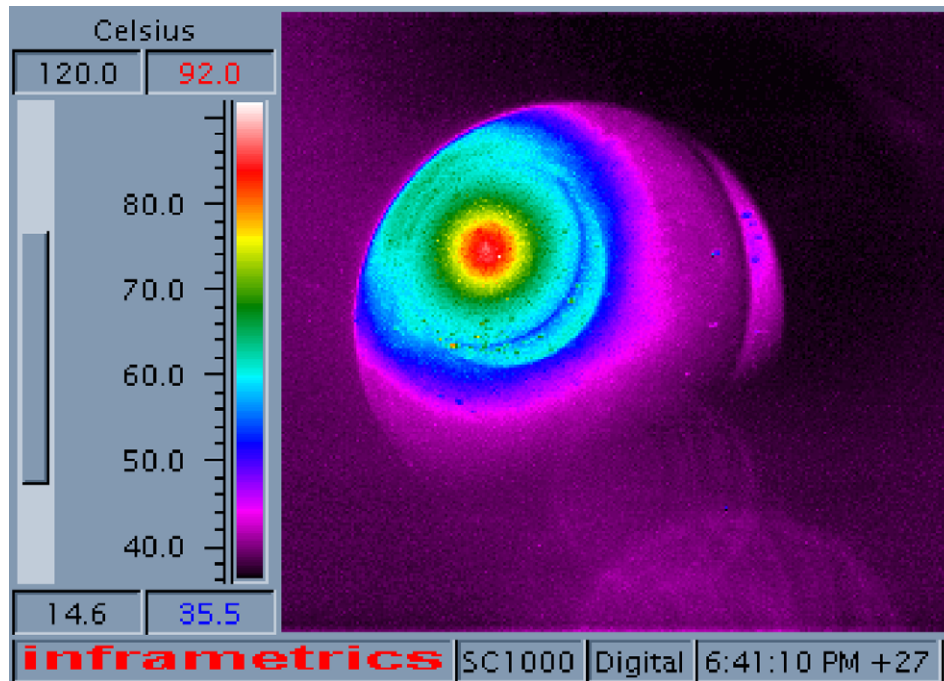
...have been addressed and resolved

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- Hard brazes, Au/Cu and others have been successful
- Arc detection and prevention are high priority
- More measurements of  $\tan(\delta)$  are being made
- Raman scattering has been developed to diagnose contamination
- Surface cleaning by grit blasting with alumina and "aqua regia" acid etch have been successful



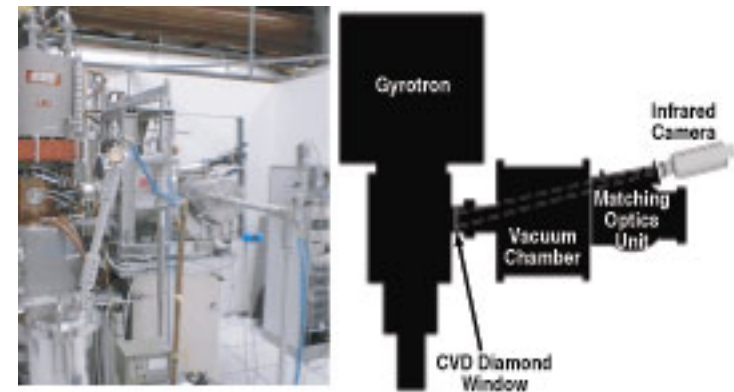
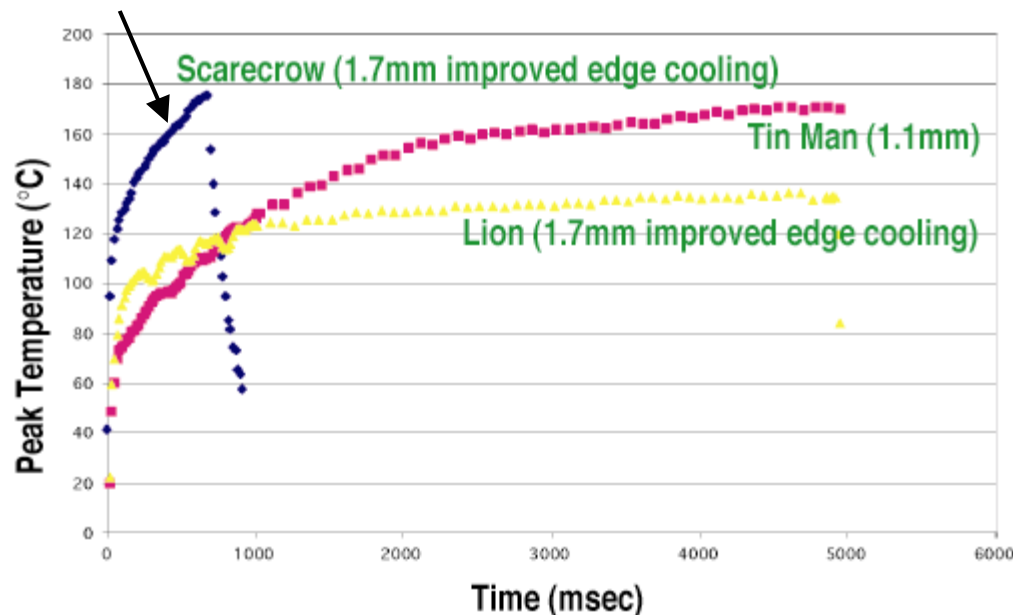
# CVD Diamond Window IR View



- A 5.0 second pulse at 800 kW, 110 GHz from the CPI *Tin Man* gyrotron at DIII-D
- Window parameters:
  - 1.1 mm thick
  - 50 mm clear aperture
  - $\tan(\delta) < 5 \times 10^{-5}$
  - $K > 1.2$  kW/m-K (4xCu)
  - Yield stress  $\sim 350$  MPa
  - $\sim \$100k$

# CVD Diamond Thermal Performance Measurements are Difficult

(coating? higher emissivity?)



Typical installation and geometry for window IR measurements

Thermal equilibrium after ~3 sec, but substantially different performance from window to window possibly due to unintended contaminant coatings

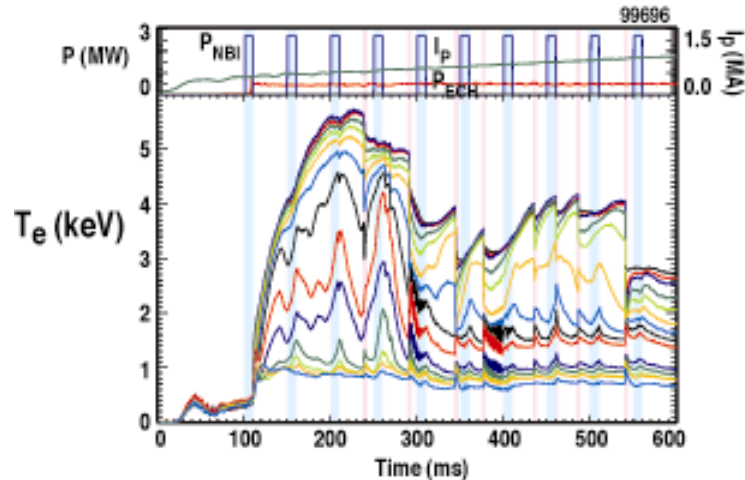
**CVD diamond is the viable solution to the gyrotron window problem**



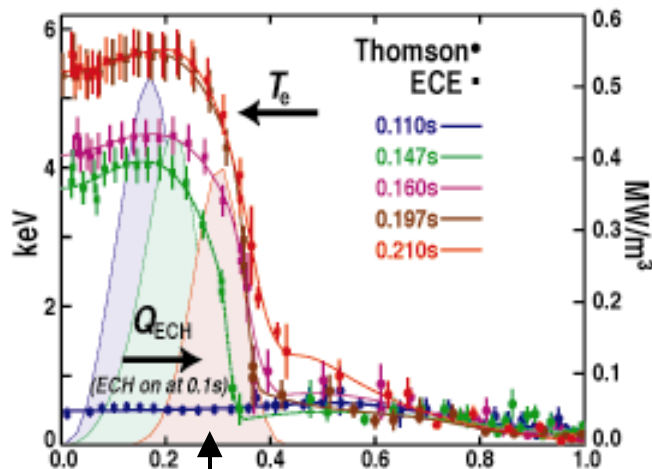
# ECH and ECCD Experiments on DIII-D



# ECH: Transport Barrier Formation with Perpendicular Injection



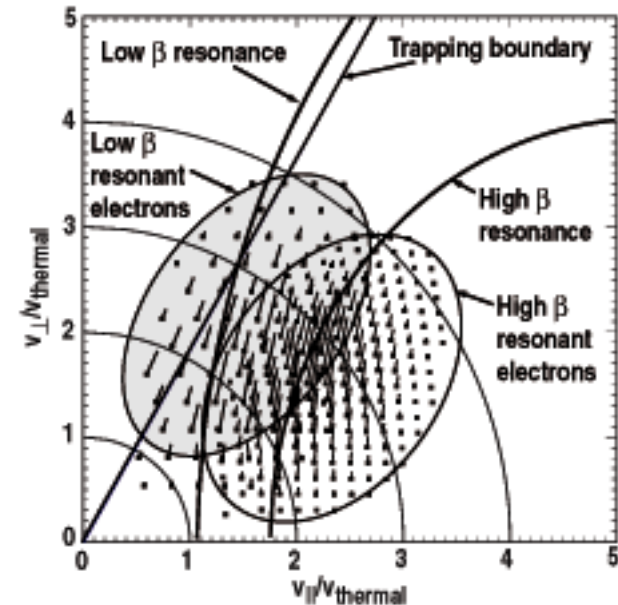
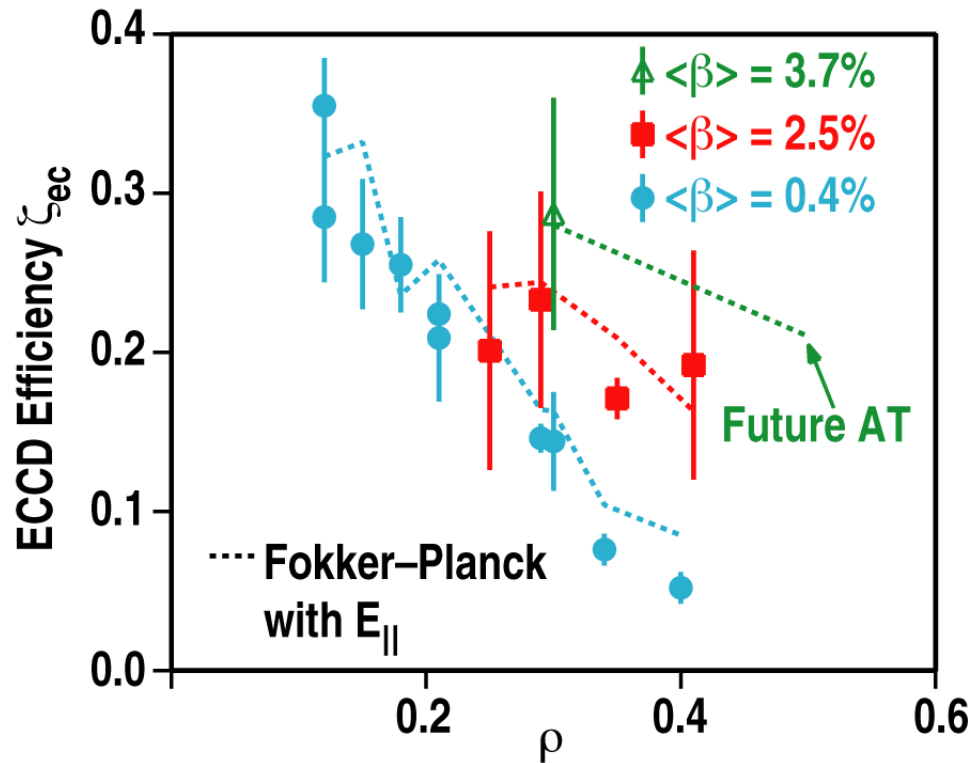
- ECH applied early to a discharge with negative central shear
- $x_e < 0.1 x^{neo}$
- Barrier lies just inside the  $2v_{ce}$  resonance
- ETG mode stabilized by the large Shafranov shift
- Record  $T_e = 15$  keV for DIII-D has been achieved this way



Power deposition profile width is ~8 cm at the 10% contour



# ECCD Efficiency is High



- $I_{ECCD} \leq 140$  kA for  $P_{RF} = 2.2$  MW
- High efficiency for off axis ECCD
- Adequate for advanced tokamak

- The efficiency stays high for off-axis drive if the plasma pressure,  $\beta$ , is high, because the resonant electrons are far from the trapping boundary.

# Use of ECCD to Suppress Instabilities

# NTM Stabilization

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1. Island width for  $m/n=3/2 \sim 7$  cm
2. -10dB width of  $j_{\text{ECCD}}$  is  $\sim 8$  cm and -3 dB width is about 3 cm

A good match between ECCD and island widths

3. About 1-2 cm accuracy is required, but some misalignment is OK
4. Within the island,  $=\nabla p \sim 0$ , so the missing bootstrap current must be restored artificially to stabilize the tearing mode.
5. For  $P_{\text{EC}} \sim 2$  MW,  $j_{\text{ECCD}} \approx 2 j_{\text{bootstrap}}$  at the  $q=3/2$  surface

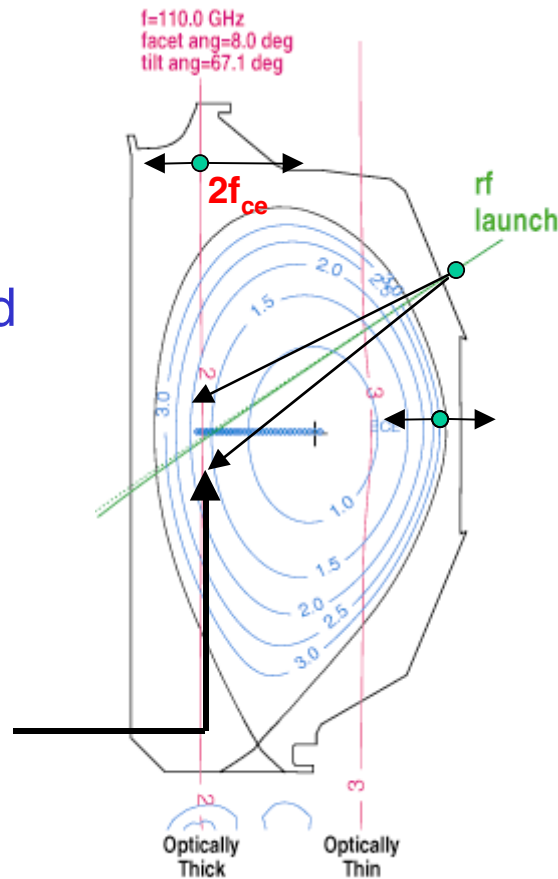
Adequate driven current with available power



# Hitting the Islands with ECCD

The absent current can be restored by ECCD, but the current must be driven exactly at the islands to within about  $\pm 1-2$  cm.

Power is absorbed at the intersection of the rf beam and the  $2f_{ce}$  resonance



The ECCD can be placed at the island location by:

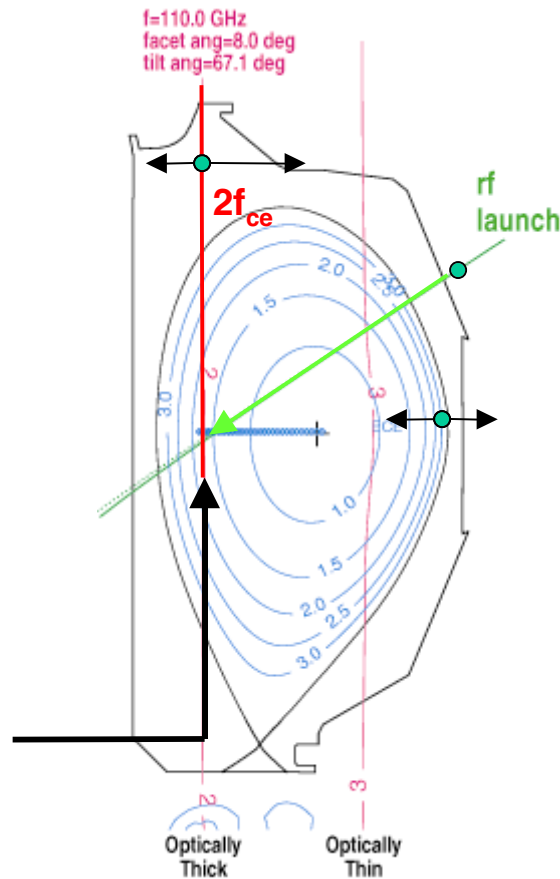
- Changing  $B_T$
- Moving the plasma
- Changing the injection angle

$\sim \pm 1$  cm radial accuracy required

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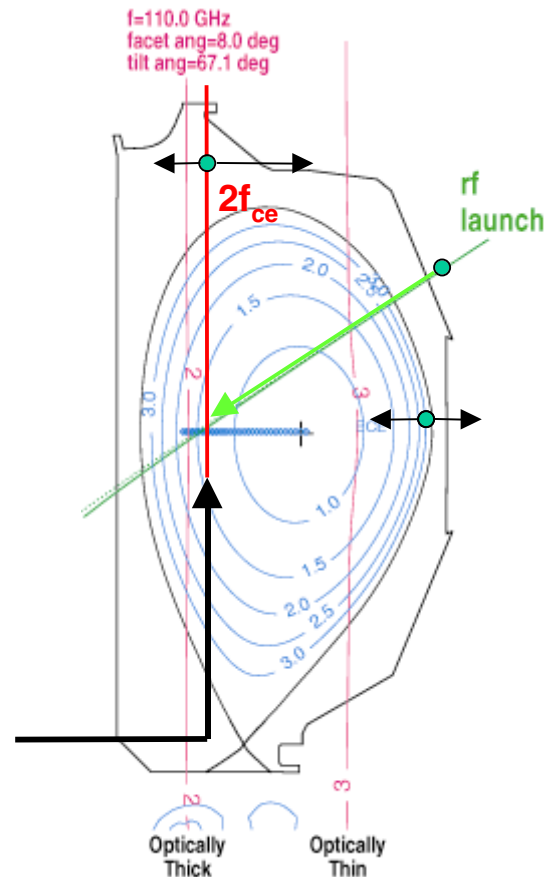
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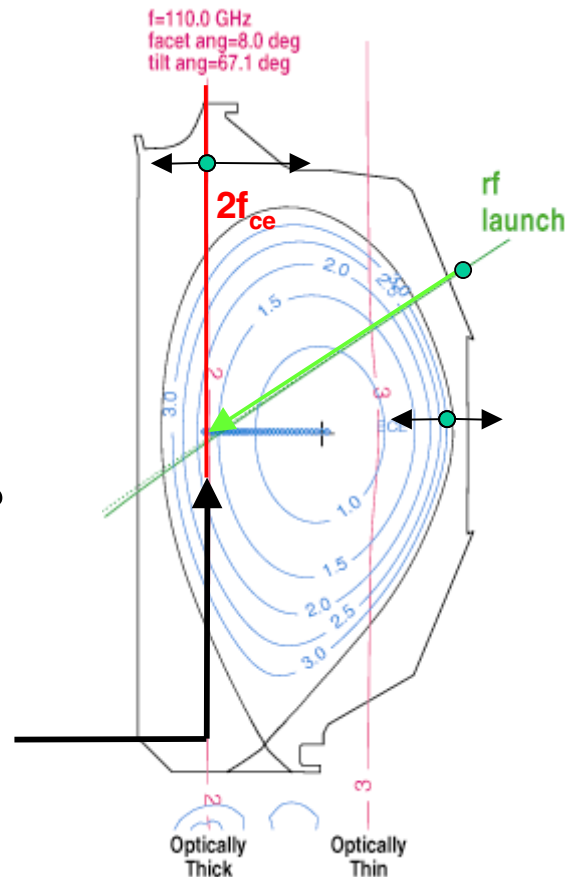
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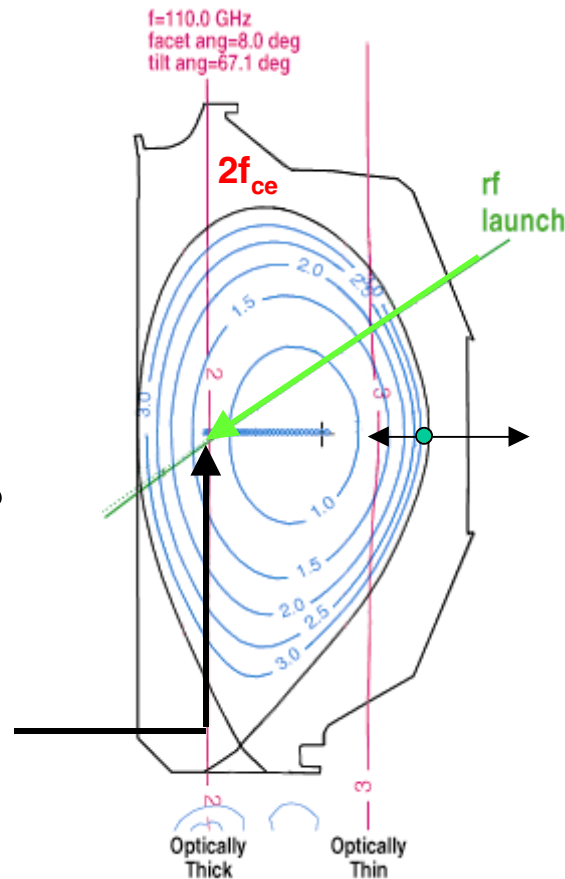
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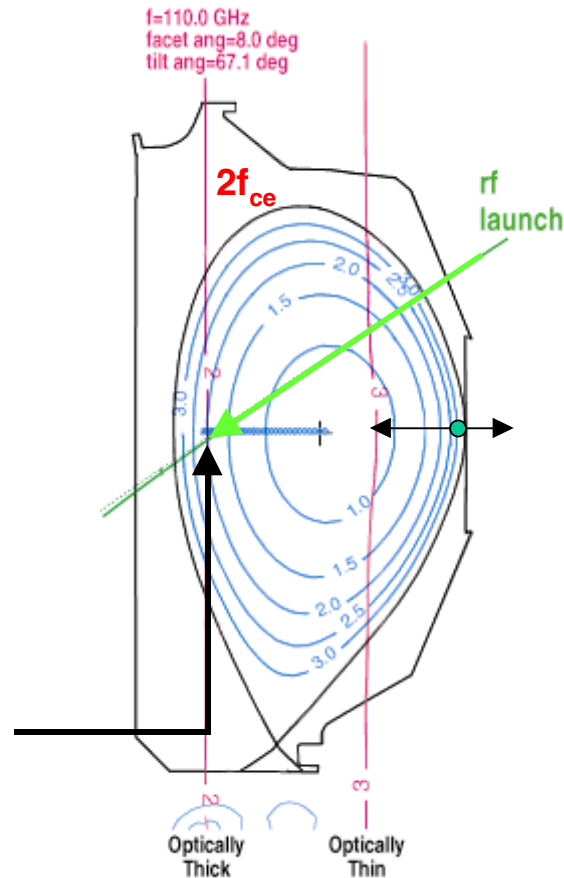
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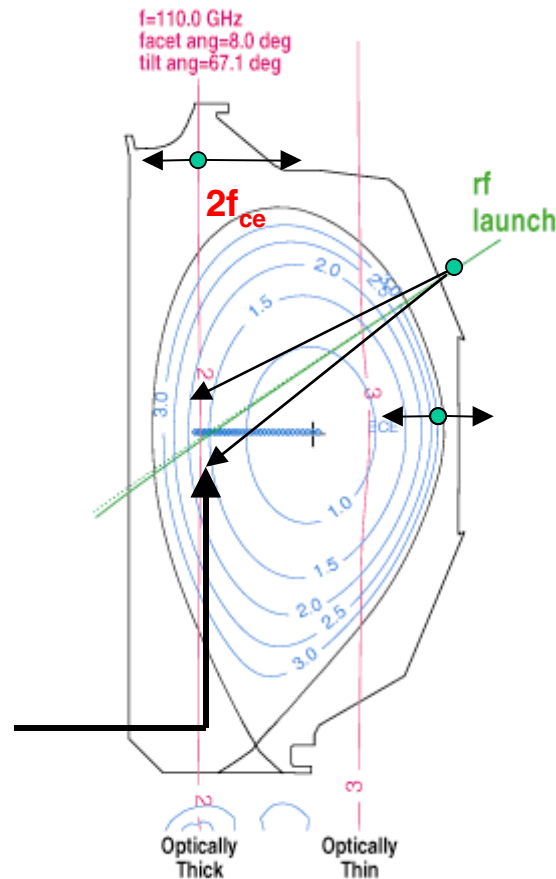
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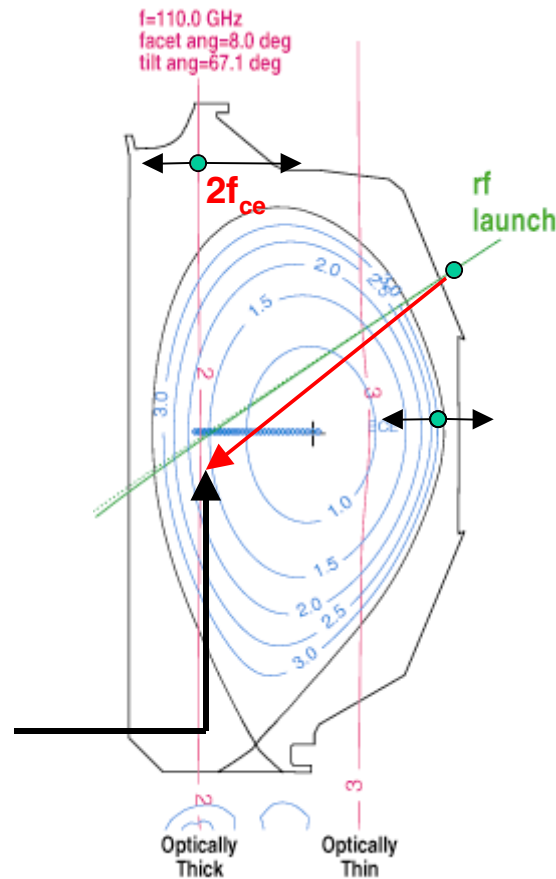
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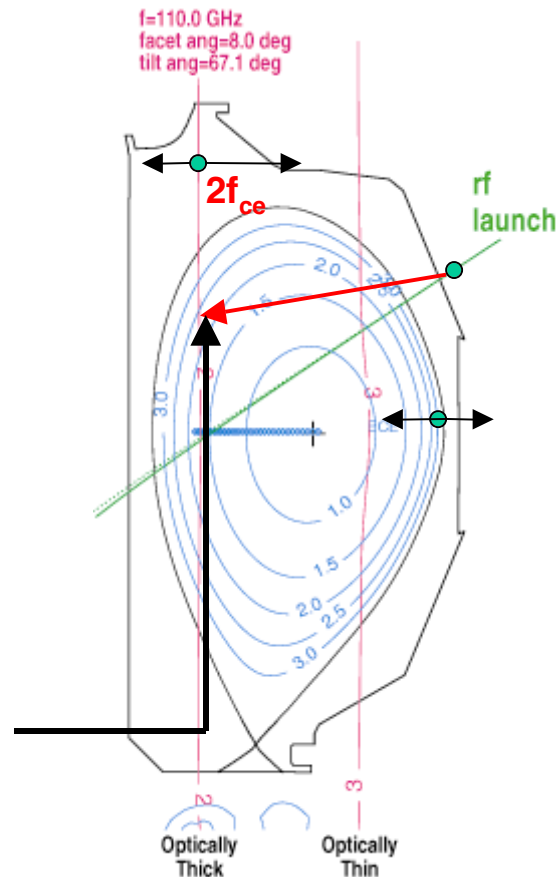
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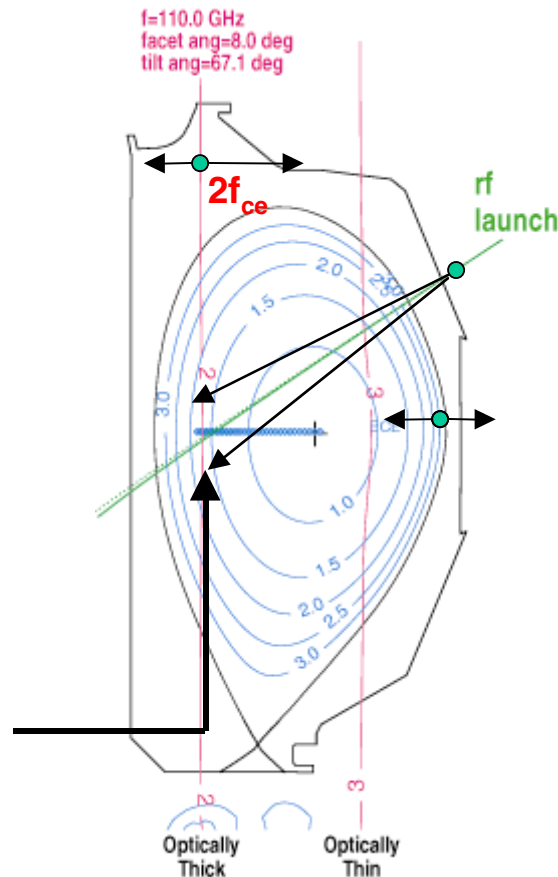
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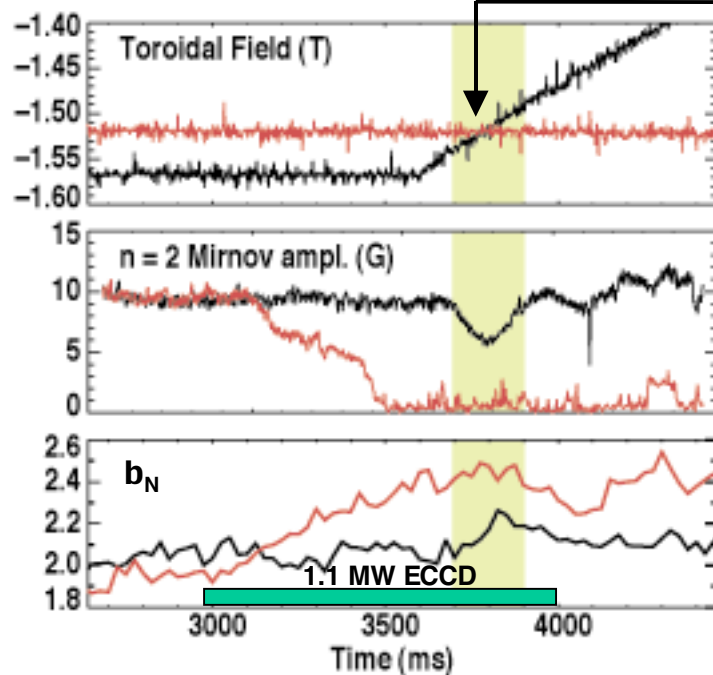


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- Moving the plasma
- Changing the injection angle

$\sim \pm 1$  cm radial accuracy required

# NTM Stabilization: Varying Tokamak $B_T$ Varies ECCD Location



For this  $B_T$  the NTM begins to die during  $B_T$  sweep

When  $B_T$  is constant at the proper value, as determined by the  $B_T$  sweep, the mode is completely eliminated

When the mode is eliminated, plasma pressure increases

Two shots...one with  $B_T$  sweep, one with constant  $B_T$

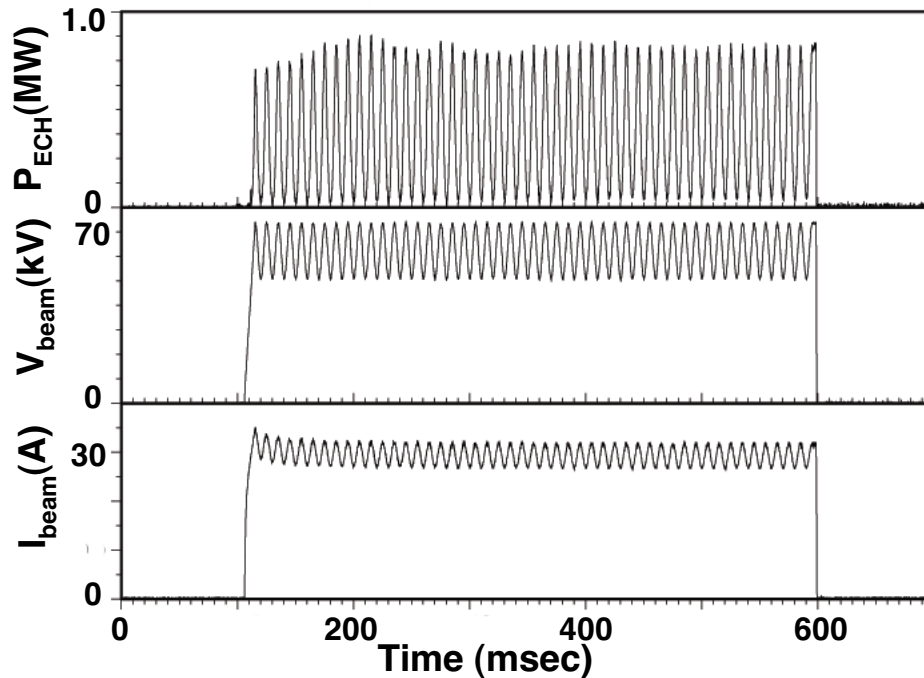
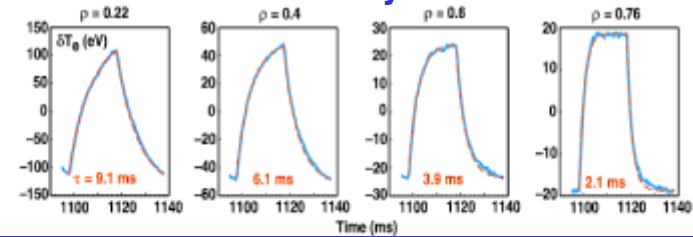
# Modulating and Controlling the ECH Power



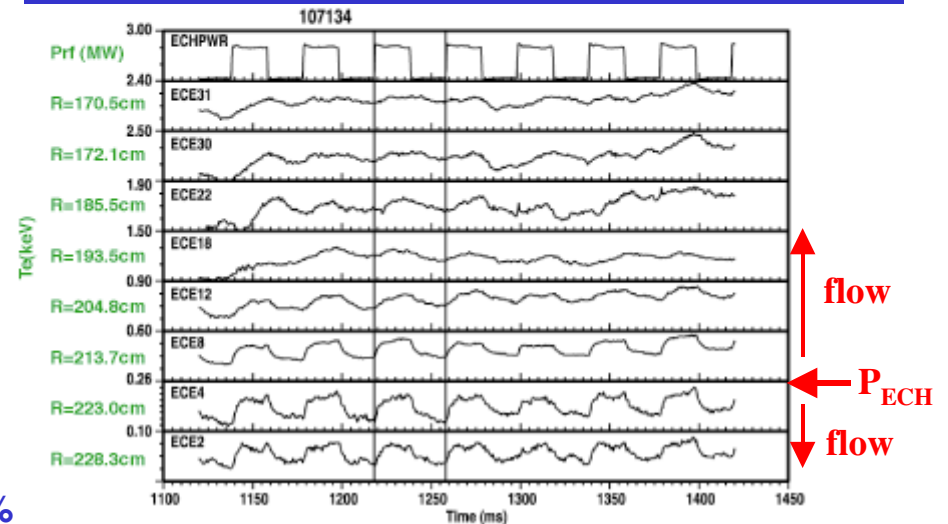


# Output Power Modulation

The shape of the time response of  $T_e$  at the location of the ECH power deposition gives the local incremental electron energy confinement time directly.



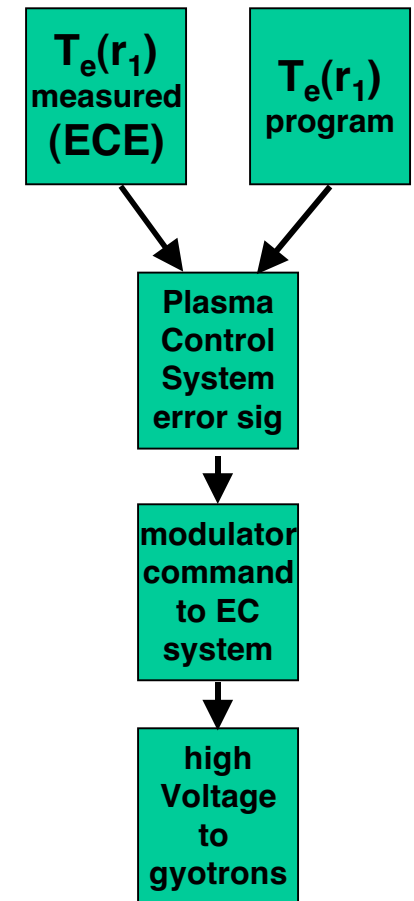
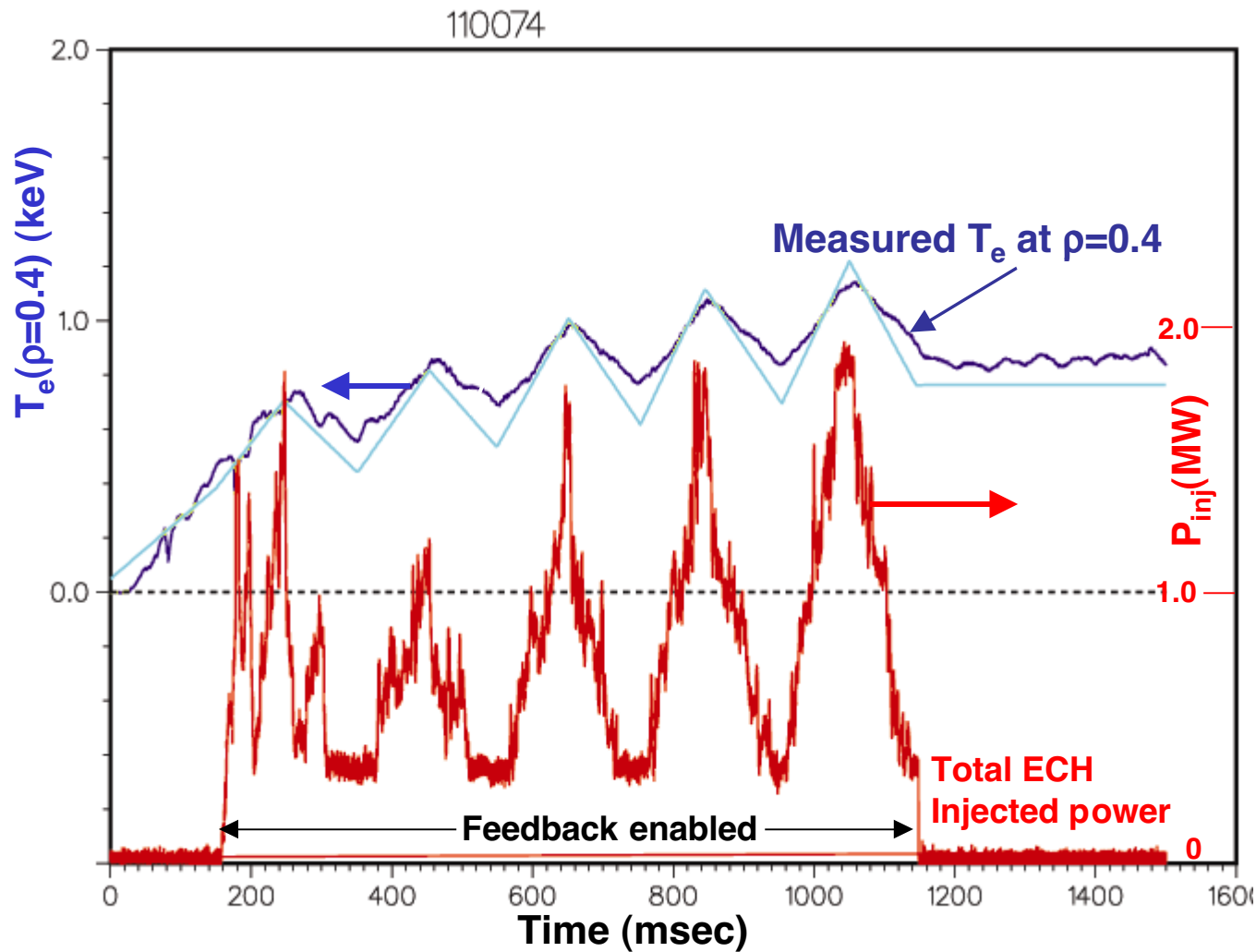
Sinusoidal modulation of a single gyrotron. A 30% decrease in the beam energy yields a 20% decrease in the beam current and a 100% modulation depth. Modulation at up to 10 kHz has been demonstrated.



Use of square wave modulation of all the ECH gyrotrons to study deposition profiles and energy transport in the electron channel



# Feedback Control of ECH Power



# Summary

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- ECH is a reliable tool for magnetic fusion research
- High power millimeter sources and components have been developed
- Physics of ECH/ECCD is understood
- A unique new group of experiments is being explored
  - control of MHD instabilities
  - transport studies
  - profile control
  - advanced tokamak operation
- Future plans for the DIII-D installation
  - 3 new gyrotrons 110 GHz, 1 MW, 10 sec pulse length
  - 8 gyrotrons operating from 4 flexible launchers
  - ~5 MW injected rf power by 2005

